RSC Advances



REVIEW

Check for updates

Cite this: RSC Adv., 2020, 10, 36413

Received 20th August 2020 Accepted 14th September 2020

DOI: 10.1039/d0ra07160a

rsc.li/rsc-advances

Anisotropic quasi-one-dimensional layered transition-metal trichalcogenides: synthesis, properties and applications[†]

Abhinandan Patra and Chandra Sekhar Rout 💷 *

The strong in-plane anisotropy and quasi-1D electronic structures of transition-metal trichalcogenides (MX_3 ; M = group IV or V transition metal; X = S, Se, or Te) have pronounced influence on moulding the properties of MX_3 materials. In particular, the infinite trigonal MX_6 prismatic chains running parallel to the *b*-axis are responsible for the manifestation of anisotropy in these materials. Several marvellous properties, such as inherent electronic, optical, electrical, magnetic, superconductivity, and charge density wave (CDW) transport properties, make transition-metal trichalcogenides (TMTCs) stand out from other 2D materials in the fields of nanoscience and materials science. In addition, with the assistance of pressure, temperature, and tensile strain, these materials and their exceptional properties can be tuned to a superior extent. The robust anisotropy and incommensurable properties make the MX_3 family fit for accomplishing quite a lot of compelling applications in the areas of field effect transistors (FETs), solar and fuel cells, lithium-ion batteries, thermoelectricity, *etc.* In this review article, a precise audit of the distinctive crystal structures, static and dynamic properties, efficacious synthesis schemes, and enthralling applications of quasi-1D MX₃ materials is made.

1. Introduction

Centre for Nano and Material Sciences, Jain University, Jain Global Campus, Jakkasandra, Ramanagaram, Bangalore-562112, India. E-mail: r.chandrasekhar@ jainuniversity.ac.in; csrout@gmail.com

† Electronic supplementary information (ESI) available. See DOI: 10.1039/d0ra07160a

The many pioneering studies based on the modern miracle material graphene¹ paved the way for other monolayered and fewlayered two-dimensional transition metal dichalcogenides (TMDCs) to be studied. They gained huge attention due to their strong tunable mechanical, electrical, optical, and



Abhinandan Patra received his M.Sc. degree in Physics from the College of Engineering and Technology under Biju Patnaik University of Technology (BPUT), Odisha, India, in 2019. He is presently pursuing his PhD degree at the Centre for Nano and Material Sciences, Jain University. His main research interests are the synthesis and comprehensive characterization of novel functionalized layered

2D nanomaterials and their composites for electrochemical storage and conversion applications.



Dr Chandra Sekhar Rout is Associate Professor at the Centre for Nano & Material Sciences, Jain University. Before joining CNMS, he was a DST-Ramanujan Fellow at IIT Bhubaneswar, India (2013–2017). He received his B.Sc. (2001) and M.Sc. (2003) degrees from Utkal University and his PhD from JNCASR, Bangalore (2008) under the supervision of Prof. C. N. R. Rao. He did post-

doctoral research at National University of Singapore (2008–2009), Purdue University, USA (2010–2012), and UNIST, South Korea (2012–2013). His research interests include 2D materials for sensors, supercapacitors and energy storage devices, field emitters, and electronic devices.

physiochemical properties originating from the low dimensionality and quantum confinement effects. In accordance with the above excellent properties, they are useful for various optoelectronic and energy storage applications. Another noteworthy family of two-dimensional materials is transition metal trichalcogenides (MX₃), which have been a source of attraction for a couple of years. These MX₃ materials possess typical electrical, optical, magnetic, and physical properties that are quite anisotropic. Therefore, linking the benefits of 2D materials (elasticity, robustness, ease of synthesis, and huge surface to volume ratios) with excellent quasi-one-dimensional (1D) properties can be reasonably fruitful for application in the unexplored directions of nanoelectronics and nanotechnology.

The weak van der Waals amalgamated crystal structures of MX3 architecturally and chemically constitute a very distinct family of compounds, where M (group IV, V, or VI) represents a metal atom and X is a chalcogen atom (S, Se, or Te), and the M-X bond is ioniccovalent in nature.6-9 The compact in-plane anisotropy and quasi one-dimensional properties of monolayer and few-layer MX₃ contribute a huge amount to configuring every single property of these materials. The prismatic MX₆ chains of MX₃ are extended along the *b*-axis to provide strong anisotropy. Pressure, temperature, and tensile strain can tune the electronic properties, and charge density wave transportation plays a pivotal role in making metal trichalcogenides a prime material of interest in the nanoscience and materials science communities. Instead of bulk or layered MX₃, monolayer metal trichalcogenides are of considerable interest in both experimental and theoretical investigations. Monolayer TiS₃ and TaS₃, fabricated through mechanical exfoliation, show amazing superconductivity and charge density wave phenomena. This breakthrough accounts for their pronounced, unparalleled, and plentiful applications in the field of nanoelectronics.

Wide amounts of research have been ongoing concerning the flexible fabrication of MX3 materials, and attempts to shed several layers to obtain monolayers have also been made in the past few years through many emerging top-down synthesis methods. These new-fangled methods include chemical vapour deposition (CVD), chemical vapour transport (CVT), solvothermal methods, mechanical and chemical exfoliation, etc. As far as this review is concerned, we report cumulative information regarding crystal structures, elementary properties, synthesis procedures, applications, and experimental and theoretical developments related to MX₃-based materials. Firstly, emblematic crystal structures and typical electrical, optical, magnetic, and CDW transport property characteristics are thoroughly discussed. Secondly, the fabrication of these materials is looked into. Lastly, the wide variety of applications of MX3, including field emission transistors,124-126,142 solar and fuel cells,139,143-148 photo-detectors and -sensors,33,139,150,151 lithium ion batteries,134,152-155 and thermoelectricity,156-161 are discussed with proper reference to previous studies.

2. Classification and crystal structures of MX_3

Layered MX₃ materials have emerged as a modern development with interesting electrical and optical properties due to their inplane anisotropy.²⁻⁴ With robust structural in-plane anisotropy, MX₃ materials combine the boons of both 2D layered material properties and quasi-1D material properties. Materials in the MX₃ family are fascinating candidates for this purpose due to their reduced in-plane bonding symmetry.²⁻⁴ These MX₃ materials can be classified into three categories (IV–X, V–X, VI–X) based on the metal (M) position in the periodic table. Here, X is the chalcogen element (S, Se, or Te); group IV elements are Ti, Zr, Hf, and Rf; group V elements are V, Nb, Ta, and Db; and group VI elements are Cr, Mo, W, and Sg. Among these materials, VI–X materials are reported to be amorphous⁵ and are less reported in the literature. A brief overview of the classification, crystal structures, and properties of widely studied MX₃ materials (IV–X, V–X) is provided in Table 1.

In most transition metal trichalcogenides, MX_6 trigonal prisms (M as the central atom and X dwelling in the prism triangular base) are stacked so as to obtain MX_3 trigonal prismatic chains, and these chains (aligned parallel to the *b*-axis of the unit cell) are covalently bonded through van der Waals forces [Fig. 1a].⁶ Due to this, these chalcogenides have the tendency to show 1D characteristics along with anisotropy. Depending on the X-X bond lengths in these MX_3 crystals, three types of chain arrangement are possible,²⁻⁴ which are outlined below:

> A one-type chain arrangement is present in $ZrSe_3$, with Se-Se bond lengths of 0.234 nm and $(Se_2)^{2-}$ pairs forming in the trigonal base.

> A two-type chain arrangement is present in TaSe₃, with Se-Se bond lengths of 0.258 nm and 0.291 nm (exceeding the value of ZrSe₃). TiS₃ crystals are an example of this type, with the arrangement: $Ti^{4+}S^{2-}(S_2)^{2-}$.

≫ A three-type chain arrangement is present in NbSe₃ unit cells, with three Se–Se bonds at the base of the trigonal prismatic chains, short (III), mean (I), and long (II), having bond lengths of 0.237 nm, 0.248 nm, and 0.291 nm, respectively. The short bond length (0.237 nm) is ascribed to $(Se_2)^{2-}$, which supports the weakening of bonds between two Se atoms and strengthens the bonds between Nb and Se atoms. These types of arrangement create an intermediate situation with Nb⁴⁺ and Nb⁵⁺.

2.1. Crystal structures and properties of IV-X type MX₃

As shown in Table 1, TiX₃, ZrX₃, and HfX₃ (X = S, Se, or Te) are in the group-IV–X family, falling into the $P2_1/m$ space group, and have been investigated for their remarkable physical and chemical properties. Of these, the crystal and band structures of TiS₃ are shown in Fig. 1a–c.^{6,8,9} Different Ti–S bond lengths along the *a* (2.65 Å) and *b* (2.45 Å) axes consequently result in highly conducting 1D chains parallel to the *b*-axis and turn out to be the reason for the solid anisotropic properties.^{2,7} In Fig. 1b,⁸ the red dashed lines show the Ti one-dimensional chain, which is also covalently bonded laterally with the *a*axis, materializing sheets and networks through van der Waals forces. The unit cell of monolayer TiS₃ is supposed to be a rectangle, whereas for bulk TiS₃, it is a monoclinic crystal with the measured lattice constants of a = 4.973 Å, b = 3.433 Å, c =8.714 Å, and $\beta = 97.74^{\circ}$.^{2,6} The nuclear binding energy of bulk

Table 1	An overview of	the crystal structures	and properties of MX ₃
---------	----------------	------------------------	-----------------------------------

Group	Transition metal	S	Se	Те
IV	Tì	Monoclinic a = 4.973 Å, $b = 3.433$ Å, $c= 8.714 Å; \beta = 97.74^{\circ}Diamagnetic; n-typesemiconductor; band gap:0.8–1 eV; Hall mobility: 30cm2 V-1 s-1 (ref. 2 and 12)$	No report	No report
	Zr	Monoclinic $a = 5.06$ Å, $b = 3.6$ Å, $c = 8.95$ Å; $\beta = 98.4^{\circ}$ Diamagnetic; p-type semiconductor; band gap: 1.8-2.5 eV; Hall mobility: 26 cm ² V ⁻¹ s ⁻¹ (ref. 12 and 52)	Monoclinic a = 5.411 Å, $b = 3.749$ Å, $c =9.44 Å; \beta = 97.45^{\circ}Diamagnetic; n-typesemiconductor; band gap:1.1 eV; Hall mobility: 3.9 cm2V-1 s-1 (ref. 29 and 164)$	Monoclinic $a = 5.863 \text{ Å}, b = 3.923 \text{ Å}, c = 10.089 \text{ Å}; \beta = 97.74^{\circ}$ Semi-metallic; $T_{\text{CDW}} = 63 \text{ K}; T_{\text{c}}$ (superconductor) = 2 K (ref. 13 and 165)
	Hf	Monoclinic $a = 5.08 \text{ Å}, b = 3.58 \text{ Å}, c = 8.96 \text{ Å}; \beta = 98.4^{\circ}$ Diamagnetic; p-type semiconductor; band gap: 1.9–3.1 eV; Hall mobility: 26 cm ² V ⁻¹ s ⁻¹ (ref. 52 and 165)	Monoclinic a = 5.31 Å, $b = 3.73$ Å, $c =9.525 Å; \beta = 97.18^{\circ}Diamagnetic; p-typesemiconductor; band gap:1.0 eV (ref. 3 and 7)$	Monoclinic $a = 5.879 \text{ Å}, b = 3.902 \text{ Å}, c = 10.056 \text{ Å}; \beta = 97.98^{\circ}$ Semi-metallic; $T_{\text{CDW}} = 93$ K; T_{c} (superconductor) = 4.3 K (ref. 15 and 166)
v	Nb	Triclinic a = 4.963 Å, $b = 6.730$ Å, $c= 9.144 Å; \beta = 97.17^{\circ}Diamagnetic;semiconductor; band gap:0.8-1.1$ eV (ref. 55 and 83) Monoclinic a = 9.68 Å, $b = 3.37$ Å, $c =14.83 Å; \beta = 109.9^{\circ}Diamagnetic;semiconductor; band gap:0.3-1.0$ eV; Hall mobility: 10-2400 cm ² V ⁻¹ s ⁻¹ (ref. 12 and 13)	Monoclinic $a = 10.009 \text{ Å}, b = 3.48 \text{ Å}, c = 15.629 \text{ Å}; \beta = 109.47^{\circ}$ Metal; $T_{\text{CDW}} = 145 \text{ K}$ and 59 K (ref. 75, 79, 94 and 164)	No report
	Та	Orthorhombic a = 36.804 Å, b = 15.173 Å, c = 3.34 Å Metal ⁸ Monoclinic a = 9.515 Å, b = 3.3412 Å, c $= 14.912 \text{ Å}; \beta = 109.99^{\circ}$ Metal ¹⁶⁶	Monoclinic a = 10.402 Å, b = 3.495 Å, c = 9.829 Å; $\beta = 106.26^{\circ}$ Metal; superconductor; $T_{c} =$ 2.1 K (ref. 55, 79 and 164)	No report

 TiS_3 is ${\sim}0.22$ per unit cell. 6,10,11 Significantly, there are no reports on $TiSe_3$ and $TiTe_3.$

All members of the ZrX₃ and HfX₃ family take the form of monoclinic crystals, whose lattice parameters are summarized in Table 1. As discussed, the layered-type crystal structure of MX₃ has the metal ion (M) in the centre of a slanted trigonal prism; stacked trigonal faces form separated columns that arrange along the *b*-axis, and the base triangle has a shape with two sides much longer than the third one.^{12–15} This criterion is satisfied by the formulation $(X^{2-})(X_2^{2-})$, with the metal oxidation state being M⁴⁺ (d⁰), leading to empty d-block bands. Due to this fact, most MX₃ compounds are reported to be semiconducting, with a band gap of ~1–2 eV, except ZrTe₃ and

HfTe₃, which are semi-metallic with superconducting properties at low temperatures.^{12–15} The crystal structure of $ZrTe_3$ is presented in Fig. 4a and b.¹⁵

2.1.1. Optical, electronic, and anisotropic properties of IV-X-type MX₃. TiS₃ is found to be an n-type semiconductor with an energy band gap of 0.8–1.0 eV, and for N = 5 layers, the band gap is just 24 meV less than that of a single layer (N = 1). For that reason, having robust conduction band maximum (CBM) and valance band maximum (VBM) energy states, the energy gap of TiS₃ does not change depending on the layer thickness.¹¹ First principles calculations on the electronic structures of mono- and few-layered films demonstrate that the properties are quite fixed and do not depend on the number of layers,



Fig. 1 (a) The crystal structure of anisotropic TiS₃ indicating the bond lengths between titanium and sulfur along the *b*-axis and *a*-axis, with shorter bonds along the *b*-axis; reproduced with permission from ref. 6, copyright: 2015, Springer Nature. (b) The calculated electronic energy band structure along the symmetry directions of the Brillouin zone ($\Gamma - Y - C - X - \Gamma$) and the projected density of states (PDOS) of the optimized structure of ML TiS₃. The direct band gap E_g of ML TiS₃ is indicated by the red arrows. The Fermi level is set to zero energy (the dashed line); reprinted with permission from ref. 8, copyright: 2019, American Chemical Society. (c) The charge distributions of the VBM and CBM states of monolayer TiS₃; republished with permission from ref. 9, permission conveyed through Copyright Clearance Center, Inc.

vertical strain, and piling order.⁹ Gomez *et al.* measured the electronic band gap and optical band gap to be 1.20 eV (with a rectification factor of 0.08 eV) and 1.07 eV (with a rectification

factor of 0.01 eV), respectively, hence demonstrating the exciton energy (the difference between the electronic band gap and optical band gap) to be 130 meV.¹⁶ Biele *et al.* demonstrated that



Fig. 2 The optical properties of TiS₃ flakes. (a) An optical microscope image showing the *a* and *b* axis directions and infrared light emission from TiS₃. (b) Photoluminescence and (c) time-resolved photoluminescence spectra and (d) the photostability of a TiS₃ flake compared to black phosphorus. Reproduced with permission from ref. 18, copyright: 2019, IOP Science. (e) Raman spectra of TiS₃ ribbons with horizontal excitation and detection polarization. (f) The intensity of the 370 cm⁻¹ Raman peak of a 3 nm-thick flake (3–4 layers) as a function of the excitation polarization angle (ref. 18). (g) The transmittance of the red, green, and blue channels as a function of the excitation polarization angle. (h) Calculated absorption spectra when the field is aligned parallel to the *b*-axis (dashed line) and the *a*-axis (solid line) with the inset showing the transmittance in the *a*-*b* plane for red (1.9 eV), green (2.4 eV), and blue (2.72 eV) excitation energies. Reproduced with permission from ref. 6; copyright: 2015, Springer Nature.

Review

RSC Advances

tuning from a direct to an indirect band gap in TiS_3 is possible *via* the application of compressive strain during the course of normal electrical transport. *Ab initio* calculations and optical absorption experiments confirmed a band gap increase of 9% (from 0.99 to 1.08 eV) upon tensile stress stimulation.¹⁷ DFT calculation reports on the strain engineering of TiS_3 monolayers demonstrate that the degree of anisotropy in mobility and effective mass can be reformed using tensile strain.¹¹

Experimental reports by Khatibi et al. showed that TiS₃ emits near infrared (NIR) light centred at about 0.91 eV (1360 nm) with undeviated polarized anisotropic photoluminescence with a radiation life span of 210 ps (Fig. 2a-d).¹⁸ The dependence of emission on the excitation power and temperature demonstrated the dominant behaviour of free and bound electronhole pairs over excitonic radiation at room and low temperature, correspondingly. TiS₃ is reported to show excellent stable emission compared to other 2D materials, such as black phosphorus, MoTe₂, etc.¹⁸ TiS₃ is one of the appealing materials in the MX₃ family due to its anisotropic optical properties. By using a force field along either the *a*-axis or *b*-axis and carrying out detection at intermediate angles between a and b, the anisotropic optical properties of 2D TiS₃ are investigated.⁶ The anisotropic optical properties survey demonstrated strong emission anisotropy along the b-axis (25% higher emission intensity than along the a-axis). Island et al. inspected the strong in-plane anisotropy of TiS₃ through angle-resolved polarization Raman spectroscopy (ARPRS).6 Compared to at room temperature, at 25 K, the in-plane conductivity in terms of anisotropy increases 2.09-fold. Fig. 2e and fo shows Raman studies of TiS₃ ribbons under different polarization conditions. Taking the *b*-axis as the favourable growth axis, four distinguishable Raman peaks (excluding one peak due to the silicon

substrate) due to TiS₃ were observed from an isolated nanoribbon on the SiO₂/Si substrate. It is reported that the intensities of all the modes can be altered *via* changing the polarization angle, whereas the peak close to 370 cm⁻¹ is found to be reliant on alignment between the polarization of the excitation laser and the *b*-axis. Furthermore, the anisotropy of the photosensitivity is verified based on the transmission of TiS3 through characteristic angles (Fig. 2h).6 The transmission reached a minimum value when the angle between the polarized excitation light source and the elongated side of the flakes was 180° (parallel to each other) in correspondence with the *b*-axis. The collected optical transmission data confirmed that TiS₃ flakes exhibit robust linear dichroism, where the properties along the *b*-axis dominate those of the *a*-axis by as much as 30-fold, which is commendable for a 2D material.6 Compared to common semiconductors and other 2D TMDCs, TiS₃ nanoribbons have a high exciton binding energy, which makes them an excellent applicant for use in optoelectronic devices and various related applications. Iyikanat et al. calculated the band gap of TiS₃ using the PBE (Perdew-Burke-Ernzerhof) approximation and HSE06 (Heyd-Scuseria-Ernzerhof functional) correction to be 0.23 eV and 1.05 eV, respectively.19 The effects of S, Ti, TiS, and double S vacancies in TiS₃ on its optical and electrical properties were also discussed based on DFT calculations by the above group (Fig. 3a-d).¹⁹ Of the four types of vacancies, except for S vacancies, the others lose their semiconducting properties and become metallic, resulting in a net magnetic moment. However, the low formation energy in the case of S vacancies assists in the opening of the energy gap of TiS₃ monolayers. The calculated magnetic moments for the Ti, TiS, and double S vacancies of ${\rm TiS}_3$ are found to be 0.5, 0.8, and 0.3 $\mu_{\rm B}$ per supercell, respectively.¹⁹ Kang et al. reported that the microelectronic properties



Fig. 3 Top views of relaxed monolayer TiS_3 with (a) S, (b) Ti, (c) double S, and (d) TiS vacancies. The black atoms illustrate removed atoms, and the dashed circles show the initial positions of the displaced atoms. Reproduced with permission from ref. 19, copyright: 2015, American Chemical Society. (e) An optical photograph of HfS₃ needles grown on the inner walls of a quartz ampoule, an optical image of ZrS₃ flakes exfoliated onto SiO₂ substrates with the *b*-axis direction shown, and an AFM image of an exfoliated TiS₃ flake with a thickness of ~5 nm. (f) A polar plot of mode III at 372 (red), 320 (black), and 321 (blue) cm⁻¹, which corresponds to thin TiS₃, ZrS₃, and HfS₃ flakes, respectively. Republished with permission from ref. 24, permission conveyed through Copyright Clearance Center, Inc.

of TiS₃ nanoribbons strongly depend on the side, whether it is a or b.²⁰ a-TiS₃ nanoribbons are reported to have the properties of a metal, having a width-dependent band gap, whereas b-TiS₃ is a semiconductor with a direct energy gap, which can be regulated by strain, is nearly self-governing, and does not hinge on the ribbon width.²⁰

ZrS₃ is reported to be a p-type semiconductor, with resistivity of 15 Ω cm at room temperature, a direct optical energy gap of 1.8-2.5 eV, and two indirect optical energy gaps of 2.055 eV (when the field is along the *b*-axis) and 2.058 eV (when the field is normal to the *b*-axis) at 4.2 K.⁴ Angle-resolved photoemission and optical measurements of ZrX_3 (X = S or Se) and HfSe₃ predict that, due to spin-orbit interactions, there is splitting of the highest occupied band into two parallel bands. The split energy rises from S to Se in the above compound, and the absorption spectra are found to be highly anisotropic considering the phonon modes and electronic transitions.²¹ Schairer et al. evaluated the optical gap energies of ZrS₃ and HfS₃ to be 2.8 and 3.1 eV.¹² In another report, Jandl et al. confirmed the presence of two polytypes in accordance with the recombination of phonon replicas of excitons localized in band tails.²² Pant et al. reported the indirect band gap of ZrS₃ to be 1.88 eV, and angle-resolved photoluminescence (PL) spectroscopy studies of ZrS₃ nanosheets demonstrated that they are highly anisotropic, which is manifested by the large PL intensity variation with polarization direction.23 Raman spectroscopy and angleresolved studies are fast and non-destructive optical methods to probe the anisotropic nature of MX₃. In this regard, Kong et al. collected Raman data from MX₃ flakes (TiS₃, ZrS₃, and HfS_3) with the longer edge (the anisotropic *b*-axis) aligned parallel to both the polarization direction of the laser and the polarization exposure path of the Raman spectrometer.²⁴ To the contrary, for TiNbS₃ alloy trichalcogenides, it is not possible to determine the anisotropic direction due to the loss of anisotropy and common defects present in the random distribution of quasi-1D MX₆ chains.²⁴ Wang et al. verified the anisotropic effects in ZrS₃ via angle-resolved absorption and angle-resolved Raman spectroscopy, and angle-resolved photocurrent studies, which gave a vibrant impression that all the properties were boosted along the *b*-axis. Angle-resolved spectroscopy studies revealed dichroic ratios of 1.73 and 1.14 for the ZrS3 nanoribbons when excited by different laser source wavelengths, *i.e.*, 450 nm and 532 nm, respectively, considering the photocurrent density.25 The change in dichroic ratio is owing to the variation of the offset angle from the *b*-axis. Jin *et al.* showed the widening and trivial shifting of peaks in the Raman spectra due to the phonon confinement effect in the cases of ZrS3 and HfS3 nanobelts.²⁶ Likewise, TiS₃ Raman spectra collected by Pawbake et al. showed the shifting of the peaks towards lower wavenumbers upon an increase in temperature (88 K to 570 K), which is attributed to thermal expansion of the lattice and anharmonic vibration.27 Apart from temperature, pressuredependent Raman spectroscopy studies were done by Wu et al., which describe the unorthodox negative pressure dependence of the A_g^{S-S} S–S molecular mode in contrast to the expected stiffening of other peaks. Numerous modes of TiS3 are reported to be doubly degenerate at ambient pressure, whereas at high pressure, this effect vanishes.²⁸

Patel et al. calculated the direct and indirect energy gaps of ZrSe₃ to be around 1.47 eV and 1.1 eV, respectively. They also found that by means of an escalation in temperature in the vicinity of 303-403 K, the anisotropy and resistivity could be decreased and increased, respectively.29 In agreement with quasi particle self-energy correction, Zhou et al. found the indirect band gap of ZrSe3 to be 1.63 eV.30 Felser et al. established a dependent relationship between the density of states and the shape of the Fermi surface in Te-Te interprism interactions in ZrTe₃.¹⁴ Zeng et al. showed that growing strain in HfS₃ resulted in a switch from an indirect to a direct band gap of 2.2 eV, whereas Tao and his group calculated the indirect and direct optical energy gaps of HfS₃ nanobelts to be 1.73 and 2.19 eV, respectively.^{31,32} As shown by photoluminescence (PL) studies, the nanobelts displayed strong emission at 483, 540, and 600 nm in response to excitation at 400 nm.32 Likewise, Zhao et al. calculated the band gaps for Zrs₃, Zrse₃, Hfs₃, and Hfse₃ to be 1.13, 0.23, 1.08, and 0.05 eV, respectively. According to their study, the p state of the chalcogen (governing the VBM) and the d state of the transition metal (governing the CBM) combined to form the band gap of the MX₃ monolayers.³³

Trisulphides, for example ZrS₃- and HfS₃-based structures, are reported to exhibit two dozen normal modes at the centre of the Brillouin zone and belong to the C_{2h} space group.^{26,34,35} Each mode is interconnected with a clutch of atomic vibrations represented by A_g , B_g , A_u , and B_u . Among these, the A_u and B_g vibrations are parallel to the MX₆ trigonal prism chains, and the A_{α} and A_{u} bands are perpendicular to the chains. Gleason *et al.* investigated the pressure-induced phases of ZrTe₃ and also analysed the temperature-dependent Raman spectra.36 It is reported that some specific phonon modes endure a dramatic linewidth reduction near the charge density wave temperature (T_{CDW}) , indicating the strong coupling of phonons with electronic degrees of freedom concomitant with the CDW (Fig. 4). Typical Raman spectra from a ZrTe₃ crystal are shown in Fig. 4c at 295 K and 6 K with normal mode displacement patterns. The lower-energy modes $(\omega_1 - \omega_3)$ and higher-energy modes $(\omega_4 - \omega_6)$ are allocated primarily to vibrations of the trigonal prismatic rods, inwardly and outwardly, respectively. Changes in the widths of the Raman bands at different temperatures (Fig. 4d and e)36 are observed, with the large reductions in the widths of ω_4 and ω_5 demonstrating strong coupling between these bands. Similarly, the downfall of the long-range-order (LRO) of the rods is attributed to the suppression of phonon bands allied to internal vibrations of the ZrTe3 prismatic rods at pressures above 10 kbar (Fig. 4f and g).³⁶

2.1.2. Electrical and magnetic properties of IV–X-type MX₃. The electronic superstructure and projected density of states (PDOS) along the symmetry direction of the Brillouin zone of the augmented assembly of monolayer TiS₃ are shown in Fig. 1b.⁸ Fig. 1c depicts the distribution of charge in the VBM and CBM of monolayer TiS₃.⁹ These details give a clear-cut idea about the high carrier mobility of 2D TiS₃ monolayers. The electron mobilities of TiS₃ are reported to be high and anisotropic, with electron mobility of 13.87 × 10³ cm² V⁻¹ s⁻¹ along

the *b*-axis, which is about 14 times greater than that along the *a*axis $(1.01 \times 10^3 \text{ cm}^2 \text{ V}^{-1} \text{ s}^{-1})$, while the hole mobility along the *a*-axis is 1.21×10^3 cm² V⁻¹ s⁻¹, about eight times higher than that along the *b*-axis $(0.15 \times 10^3 \text{ cm}^2 \text{ V}^{-1} \text{ s}^{-1})$.¹⁰ DFT calculation reports on the strain engineering of TiS₃ monolayers demonstrated that the extent of the anisotropy of both mobility and effective mass changed as a result of the influence of tensile strain. Strain engineering leads to an order-of-magnitude increase in the mobility of acoustic phonons at 300 K (100 K), *i.e.*, from 1.71×10^4 (5.13×10^4) cm² V⁻¹ s⁻¹ to 5.53×10^5 (1.66 \times 10⁶) cm² V⁻¹ s⁻¹.¹¹ Investigations into the temperature dependence of resistance along the chains (b-axis) and across the chains (a-axis) of TiS₃ are reported to show non-linear conductivity. The observed non-linear conduction in TiS₃ brings to mind quasi-1D conducting behaviour with a sliding charge density wave.37

In quasi-1D conductors, the condensations of electrons into CDWs arises due to Fermi surface instability, and they form a deformable medium that affects their overall static and dynamic properties, giving rise to metallic stability and hysteresis. Low-dimensional materials, including anisotropic 2D MX₃ layered structures, from time to time lose their LRO and orthodox symmetry, resulting in Fermi surface instability and forming a presumed charge density wave (CDW).^{38,39} ZrTe₃ is one attention-grabbing material in the type IV-X MX₃ family, which is reported to have anisotropic nature, with a CDW at 63 K and superconductivity at 2 K.^{14,15,40–42} Other reports on ZrTe₃ revealed a CDW transition at 63–70 K due to resistivity inconsistency along the *a*-axis, but not along the conventional anisotropic *b*-axis.^{41,43} Canadell *et al.* predicted that ZrTe₃ is

a type-B structure with shorter X-X contacts between adjacent MX₃ units. The type-B structure of ZrTe₃ plays a crucial role in determining the semi-metallic nature of the ZrTe₃ chains.¹³ Zhu et al. reported a comparison of the electrical and superconducting properties of ZrTe₃ single crystals prepared at low (735 °C) and high (950 °C) temperatures.¹⁵ From resistive, colorimetric, and magnetic studies, bulk superconductivity is perceived in the HT-ZrTe₃ crystals with the help of doping after a certain temperature, *i.e.*, 4 K, but not in the LT-ZrTe₃ crystals. The difference in electrical properties is attributed to the suppression of CDWs through growth-induced structural disorder at high temperature.15 Polarized Raman measurements and first principles calculations demonstrated that precise structural vibrational arrangements from longitudinal distortions of the Te(II)-Te(III) chains had a strong association with the conduction of electrons, leading to the formation of CDWs in ZrTe₃.⁴⁴⁻⁴⁶ Pressure-dependent electrical properties investigations revealed that the CDW transition temperature (T_{CDW}) of ZrTe₃ was initially amplified, then diminished at 2 GPa, and quickly vanished at 5 GPa, but superconductivity was shown at a pressure level of up to 11 GPa.47 However, Hoesch et al. performed low-temperature and high-pressure single crystal X-ray diffraction studies along with ab initio DFT studies to show that the reported abrupt demise of the CDW phase is due to instability in the Fermi surface above 5 GPa.48 Zhu et al. reported the presence of different bands, including bands with flat and dispersive profiles, along with the amalgamation of chalcogen (high mobility) and metal (low mobility) derived bands in the Fermi surface of ZrTe₃. Due to the suppression of long-range CDW order, superconductivity materialises in Se-



Fig. 4 The crystal structure of $ZrTe_3$: (a) quasi-one-dimensional trigonal prism packing along the *b* axis and (b) a quasi-two-dimensional $ZrTe_3$ layer along the *a*-*c* plane; reprinted with permission from ref. 15, copyright: 2013, American Physical Society. (c) Raman spectra of $ZrTe_3$ at 6 K and 295 K. (d and e) Temperature-dependent Raman spectra at ambient pressure and (f and g) pressure-dependent Raman spectra at *T* = 3 K. Reprinted with permission from ref. 36, copyright; 2013, American Physical Society.

doped $ZrTe_3$.⁴⁹ The superconductivity critical temperature (T_c) increased up to 4 K, but after that, additional Se doping caused a reduction in T_c and filamentary superconductivity in $ZrTe_{3-x}Se_x$ ($0 \le x \le 0.1$).⁴⁹ Polycrystalline $ZrTe_3$ is testified to show a superconducting transition temperature of 5.2 K and a $T_{\rm CDW}$ value of ~63 K, both co-existing at ambient pressure.⁵⁰ The intercalation of Ag and Cu into ZrTe₃ favoured an escalation in electrical conductivity and resulted in CDW anomalies, which is confirmed from DC magnetisation results, whereas it had no role on T_{CDW} and T_{c} .⁵⁰ Li *et al.* reported CDW formation at $T_{\rm CDW} = 93$ K with typical anisotropy.⁵¹ Conductivity measurements parallel to the *a*-axis (ρ_a) and *b*-axis (ρ_b) of a HfTe₃ crystal gave a direct indication of the disorder-related superconductor fluctuations in ρ_b at 4.3 K. Also, a superconducting phase with $T_{\rm c} = 1.7$ K co-exists with a lower $T_{\rm CDW}$ value of 80 K in a polycrystalline sample, whose generation could be attributed to enriched disorder scattering or unintended carrier doping.51 A combined experimental and computational study by Hu et al. explored a new concept, which emphasizes that phonon-electron coupling helps in the construction of CDWs in ZrTe₃. However, their study depicted that the breaching of fractional electronic gaps in the CDW state depends upon the phonon-electron momentum and coupling.44 The resistivity and Hall mobility at room temperature of ZrSe₃ were calculated by Ikari *et al.* to be about 9×10^2 Ω cm and 0.45 cm² V⁻¹ s⁻¹, respectively.⁵²

Lai et al. reported a comparative investigation into the magnetic properties and tensile strain response of N-a(b)-TiS₃ nanoribbons, where *a*-TiS₃ and *b*-TiS₃ are nanoribbons reviewed along either the *a*- or *b*-axis and *N* indicates the number of Ti atoms in the monoclinic cell of the ribbons.53 It was found that the magnetic ground state was a ferromagnetic (FM) metal when N was equal to an odd number, whereas it behaved like an antiferromagnetic (AFM) metal when N was equal to an even number for N-a-TiS₃ nanoribbons. Tensile strain (6%) could be used to tune 9-a(b)-TiS₃ nanoribbons from a FM metal to a half metal. Similarly, tensile strain (4%) also could cause an AFM to FM transition in 10-a-TiS₃ nanoribbons.⁵³

2.2. Crystal structures and properties of V-X-type MX₃

Apart from IV-X-type MX₃, V-X-type MX₃ has its own presence in the family of metal trichalcogenides with extraordinary

physical, chemical, and electrical properties. NbX₃ and TaX₃ materials with X = S, Se, or Te belong to the V-X family and are strongly anisotropic materials consisting of conducting chains weakly attached by van der Waals forces (Table 1).54,55 Among these MX₃ materials, NbS₃ is reported to have six types of polymorph, which are summarized in Table 2. NbS_{3-I} has a monoclinic crystal structure, which was first proposed in 1960 and experimentally verified via single-crystal X-ray diffraction studies in 1978.56,57 NbS3-I is reported to be a semiconducting material with a band gap of \sim 0.66–1.0 eV, and its important feature is the bond-pairing between two Nb atoms along the NbS₃ primary chain axis, with a bond length of \sim 3 Å and creating a 3.7 Å space.58-62 The NbS3-II polymorph was first acknowledged in 1978 following electron diffraction experiments, with weak pair satellite diffraction streaks that resolve into rows of spots upon modifications in temperature.^{63,64} It is proposed that NbS_{3-II} is an elevated structure of NbS_{3-I} with different types of chain accretion, and the rows of spots arise at random positions with analogous separation to NbS_{3-I} (Table 2). NbS_{3-II} is testified to have three CDWs at 150 K, 330-370 K, and 620-650 K.61 In 1982, Kikkawa and co-workers obtained monoclinic NbS3-HP via the extraordinary high-pressure modification of NbS3 synthesized at 700 °C with 2 GPa pressure.65,66 Zettl et al. produced NbS_{3-III} in 1982, which was distinctively different from the I and II phases.⁶⁷ In NbS_{3-III}, (001) reflections from the XRD data showed a similar *c*-axis as that reported for NbS_{3-I}, but the monoclinic angle was increased to 98° – 99° and $T_{\rm CDW}$ was ~155 K. Zybtsev confirmed the low and high ohmic nature of NbS₃, with CDW transitions at 150 K (both low and high ohmic) and 360 K (low ohmic).66 The low ohmic and high ohmic NbS₃ was assigned as NbS_{3-II} and NbS_{3-III}, respectively, with NbS_{3-III} designated as a sub-phase of NbS_{3-II}. For the first time, Bloodgood et al. reported NbS_{3-IV} and NbS_{3-V} polymorphs of the NbS3 monoclinic crystal structure.55 The NbS3-IV structure is constructed from NbS₆ trigonal prismatic chains with a bond length between Nb atoms of 3.0448 Å, and the chain axis is along the *a*-axis instead of the *b*-axis like other conventional MX_3 materials. For NbS_{3-V}, the Nb–Nb bond length is 3.358 Å. The bonds in NbS_{3-IV} and NbS_{3-V} are along the chains, with an AB and ABCDE recapping categorization of chain bilayers, analogous to $NbS_{3\text{-}I\text{-}}$. The crystal structures of $NbS_{3\text{-}I\text{-}}$, $NbS_{3\text{-}IV}$, and NbS_{3-V} are given in Fig. 5, with a complete overview of unit cells and layers from different perspectives. In the case of NbS₃.

Table 2 Su	mmarized data of the crystal structures, sy	ynthesis conditions, and Nb–Nb bond lengths of different pha	ases of NbS ₃ cr	ystals
Material	Crystal structure $a, b, c (Å); \alpha, \beta, \gamma (°)$	Synthesis conditions	Nb–Nb (Å)	Ref. no.
NbS _{3-I}	4.963, 6.730, 9.144; 90, 97.17, 90	$NbS_2Cl_2;588\ ^\circ C$ (source)/569 $^\circ C$ (sink); 48 h; slow cooling	3.045, 3.702	57
NbS _{3-HP}	9.68, 3.37, 14.83; 90, 109.9, 90	Nb + S; 700 °C at 2 GPa; 0.5 h	3.370	131
NbS _{3-II}	9.9, 3.4, 18.3; 90, 97, 90	Nb + S; 600 °C (source)/580 °C; 15 days	_	61 and 99
NbS _{3-II}	9.1-9.6, 18.7-19.9, 3.4; 90, 97-98, 90	Nb + S; 500 °C	_	60
NbS _{3-III}	\sim 5, —, \sim 9; 90, 98–99, 90	Nb ₂ + S; 550 °C; 21 days; 400 °C, 48 h (48 h, air quenching)	_	67
NbS _{3-IV}	6.7515(5), 4.9736(4), 18.1315(13); 90, 90.116(2), 90	Nb + S, I_2 transport, 70 $^{\circ}\mathrm{C}$ (source)/570 $^{\circ}\mathrm{C}$ (sink), 10 days	3.0448(8), 3.7087(8)	55
NbS _{3-V}	4.950(5), 3.358(4), 9.079(10); 90, 97.35(2), 90	Nb + S, 10% S, I $_2$ transport, 670 $^{\circ}\mathrm{C}$ (source)/570 $^{\circ}\mathrm{C}$ (sink), 10 days	3.358(4)	55



Fig. 5 The crystal structure of NbS_{3-I}, NbS_{3-IV}, and NbS_{3-V}: unit cells, chain cross-sections, layers, and perspective views. Reproduced with permission from ref. 55, copyright: 2017, Application Infrastructure Provider.

 $_{\rm IV}$, there are up to twice as many chains per unit cell compared to NbS_{3-I}, since the *c*-axis is doubled, and it displays the properties of a semiconductor.⁵⁵

In 1975, single-crystal NbSe₃ was prepared by Meerschaut *et al.*, and single-crystal XRD studies established the monoclinic structure, consisting of inestimable selenium trigonal prismatic chains loaded on top of each other with shared triangular faces.⁶⁸⁻⁷⁰ Similar to other MX₃-based 2D materials, the structural arrangement with strong chemical bonding anisotropy makes NbSe₃ crystals a tempting material with novel physical and chemical properties. The Se–Se bond lengths are testified to be 2.37 Å and 2.49 Å, respectively, with CDWs at 145 K and 59 K, and the Nb–Se bonds are strongly covalent–ionic in nature.^{70–73} From scanning tunnelling microscopy studies of NbSe₃, it is clear that there are three distinguishable chains (I, II, and III) in the NbSe₃ unit cell at all temperature.⁷⁴ The III chains are identified by their association with the CDW modulation vector q^1 , and the two remaining chains are named I and II.

Among TaX₃-based TMTCs, TaS₃ and TaSe₃ have been investigated due to their various fundamental microelectronic properties, which range from insulating to metallic conducting.^{65,75} TaS₃ was first described by Blitz and Kocher in 1938 and later through XRD studies implemented by Jellinek in 1962.^{76,77} There are two commonly referenced structures of TaS₃, a monoclinic state (m-TaS₃) and an orthorhombic state (o-TaS₃) (structure shown in Fig. 6a)¹⁰⁴ (Table 1). Meerschaut *et al.* reported the complete structure of m-TaS₃ with the space group $P2_1/m$, and the lattice constants are a = 9.515(2) Å, b = 3.3412(4) Å, c = 14.912(2) Å, and $\beta = 109.99^{\circ}$.⁷⁵ o-TaS₃ forms in the space group $C222_1$ and the lattice constants are a = 36.804 Å, b = 15.173 Å, and c = 3.340 Å.^{65,77} A high-pressure m_{hp}-TaS₃ phase with the identical space group to m-TaS₃ has similar lattice parameters, expect there is a deviation of β by 3°.⁶⁵ m-TaS₃ is



Fig. 6 (a) The orthorhombic structure of TaS₃. (b and c) FESEM images of TaS₃ nanobelts. (d) Temperature-dependent resistance changes of a single nanoribbon, with the inset showing a fabricated device. (e) Current–voltage curves and (f) differential conductance as a function of voltage measured at specific temperatures, with the inset of (f) showing the temperature dependence of the threshold voltage. Republished with permission from ref. 104, permission conveyed through Copyright Clearance Center, Inc.

a low-dimensional conductor with inestimable chains of tantalum atoms along the *b*-axis of the primitive cell. The remarkable properties of bulk and few-layer TaS₃ are directly correlated to the crystal structure, specifically the chains of tantalum atoms and the *b*-direction of the unit cell, which leads to quasi-1D properties. TaSe₃ belongs to the V-X group of MX₃ with a monoclinic crystal structure, in which the unit cell consists of stacks of Ta atoms, each of which are fused to three Se atoms above and below the *b*-axis.^{78,136} The monoclinic crystal structure of TaSe₃ was first recorded by Bjerkelund and Kjekshus in 1965 with *a* = 10.402 Å, *b* = 3.495 Å, *c* = 9.829 Å, and β = 106.26°.^{79,80} The inter-planar distance (nearly 4 Å) is more than the distance between the Ta atoms (3.495 Å), which gives clear evidence for the quasi-1D properties of TaSe₃.⁷⁹

2.2.1. Electrical, optical, and magnetic properties of V–Xtype MX₃. As discussed, from structural and supporting spectroscopic data analysis, the V–X type MX₃ phases can be represented by the ionic formula $M^{4+}(X_2)^{2-}X^{2-}$. The dichalcogenide groups, $(X_2)^{2-}$, are considered to be electron reservoirs and provide the MX₃ phases with some astonishing properties. NbS₃₋₁ is detailed to be a semiconductor with Nb–Nb (d¹–d¹) pairing in each chain. The pressure-dependent electrical properties of a quasi-one-dimensional NbS₃ conductor demonstrate that whenever there is an enlargement in conductivity by six orders of magnitude at pressures of 3–4 GPa, there will be an insulator–metal transition.⁸¹ Furthermore, if the local conduction activation energy increases, then there will be an additional transition in harmony with the temperature dependence of resistance. Fedorov et al. reported the physical process and electrical properties of NbX3 thin-film FETs based on colloidal powder samples subject to ultrasonication in different solvents.82 In isopropyl-alcohol and ethanol-water mixtures, the concentrations of NbSe₃ were found to be 0.332 g L⁻¹ and 0.443 g L^{-1} , respectively, which are the uppermost among all the used solvents. The highest carrier mobility is observed in NbS₃ films obtained from the ethanol-water mixture colloidal solution $[1200-2400 \text{ cm}^2 \text{ V}^{-1} \text{ s}^{-1}]$, with n-type conductivity. The measured carrier mobility in NbS3-CH3CN colloidal solution is $\sim 10 \text{ cm}^2 \text{ V}^{-1} \text{ s}^{-1}$, with p-type doping.⁸² However, from quantum chemical studies, an understanding of electronic transitions (electron transfer from the molecular orbitals of bonding Nb-Nb bonds to anti-bonding Nb-Nb bonds) through the excitation of Nb-Nb bonds has allowed this to come to light as a novel concept.83 Wu et al. incorporated a low concentration of Ti (0.05-0.18%) into the NbS₃₋₁ host matrix, which alters the phase from triclinic to monoclinic.84 Speculative studies suggest that the phase transition can be attributed to an increase in the entire energy of the triclinic phase via p-type doping induced by titanium atoms, which have one less electron in the valance shell compared to niobium. The alloyed NbS3 preserved its crystallinity, and optical and angle-resolved Raman measurements provided information about the crystalline anisotropy and its levels.84 From polarized infrared reflection and transmission studies, the absorption co-efficient for NbS_{3-I} was



Fig. 7 A schematic diagram showing the properties of quasi-1D MX₃. Resistivity figure reprinted with permission from ref. 78, copyright: 2019, American Chemical Society; in-plane anisotropy figure republished with permission from ref. 9, permission conveyed through Copyright Clearance Center, Inc. (2016); superconductivity figure reproduced with permission from ref. 124, copyright: 2015, Royal Society of Chemistry; optical properties figure reproduced with permission from ref. 6, copyright: 2019, IOP Science; carrier mobility figure reprinted with permission from ref. 78, copyright: 2019, American Chemical Society; CDW properties figure republished with permission from ref. 104, permission conveyed through Copyright Clearance Center, Inc.; band gap figure reproduced with permission from ref. 6, copyright: 2019, IOP Science; magnetic properties figure reproduced with permission from ref. 9, copyright: 2015, American Chemical Society.

RSC Advances

calculated by Itkis at two different temperatures (300 and 8.5 K).⁶⁰ Electron–hole excitations across the Peierls gap⁸⁵ and soliton-like excitations in the superstructure led to absorption in the spectral range >6700 cm⁻¹ and <6700 cm⁻¹, respectively.⁶⁰ The UV-visible absorption spectrum (250–1000 nm) at 300 K and infrared and Raman spectra at 300 K (650–10 cm⁻¹) and 100 K (650–180 cm⁻¹) of NbS₃ were obtained by Sourisseau *et al.*⁸⁶ Their findings reveal the presence of absorbing semiconducting characteristics from UV spectroscopy, and they found 23 Raman bands and 18 infrared bands, which are close to the theoretical results.⁸⁶

Monoclinic NbSe3 consists of three equidistantly placed metal chains with different $(Se_2)^{2-}$ groups, and it is reported to show metallic conductivity with two charge density wave temperatures of 145 K and 59 K.^{69,87,88} Chaussy et al. reported two phase-transition temperatures of NbSe3 crystals at 145 K and 59 K based on electrical resistivity, magnetic susceptibility, and heat capacity measurements.87 As per their revisions, when the temperature decreased, the resistivity (ρ) decreased, showing the behaviour of a metal, and saturation was reached below 10 K. The maximum specific heat capacity was attained at 49 K and gradually decreased at T = 0 K. It was found to be diamagnetic at 4.2 K, and for fibres and powder samples of NbSe₃, the magnetization values were equal to 1.35×10^{-7} emu g^{-1} (attributed to a parallel orientation to the magnetic field) and 5×10^{-7} emu g⁻¹ (attributed to a random orientation to the magnetic field), respectively.87 Whiskers of NbSe3 and Fe-doped NbSe₃ nanowires also showed two anomalies in resistivity that were adjunct to the CDW transitions at 140 K and 50 K.89 The successful doping of Fe atoms can be observed based on the strengthening of both the threshold fields, E_{T_1} and E_{T_2} . Fourprobe resistivity measurements of single-crystal NbSe3 nanowires showed the expected CDW transitions at $T_1 = 142$ K and $T_2 = 58$ K, and there was no magnetoresistance above the higher $T_{\rm CDW}$ value and positive magnetoresistance below the lower $T_{\rm CDW}$ value.⁷² Ido *et al.* explored the effects of pressure on CDW formation and superconductivity in NbSe3 via resistivity and diamagnetic measurements.90 It was observed that both the CDW transition temperatures T_1 and T_2 decreased steadily with an increase in pressure, while they later changed abruptly above 6 kbar pressure and tended to zero above $P_{\rm c} = 7.5$ kbar (superconductivity appeared). The change in superconductivity arose from a clampdown on electron-phonon coupling.90 Latyshev et al. showed that the induction of oscillations into nonlinear CDW conductivity could be attributed to columnar defects in NbSe₃, which fluctuated with a magnetic field when the field was oriented parallel to the axes of the defects.73,91 Due to the CDW transitions, there were ample signs of electronphonon scattering affecting the transport properties relating to the thermal conductivity of the lattice of NbSe3 nanowires.92 Ong et al. performed Hall measurements of NbSe₃ and showed that at both T_{CDW} values there is an increase in Hall resistivity $(R_{\rm H})$.⁹³ But this was self-regulating below 3 K, and with an increase in the field value, it saturated at 2.3 \times 10⁻⁶ m³ C⁻¹. Surprisingly, the value of $R_{\rm H}$ was 4.1 \times 10⁻⁷ m³ C⁻¹ at 2 K.⁹³

Resistivity measurements and electron diffraction studies of $m-TaS_3$ and $o-TaS_3$ showed two transition temperatures (240 K

and 160 K), which were interpreted as succeeding Peierls transitions on the diverse chain types of TaS₃.⁹⁴ For o-TaS₃, as the temperature dropped below the ambient temperature, the resistance gradually rose up to 230 K and then increased sharply. However, for m-TaS₃, this happened in a typical manner, *i.e.*, there was a sequential decrease and increase in resistance at 270, 220, and 180 K.94 The Peierls transition temperature, the temperature at which the slope of R vs. Tattains its maximum, was also shown by Roucau et al. Peierls transitions in quasi-1D conductors are associated with intrinsic superstructures.94 Polarized Raman scattering studies of o-TaS3 demonstrated that at the Fermi surface, the formation of a CDW gap was held responsible for the reduction in free carriers.95 Thus, the scattering intensity decreased from interband processes along with an increase in the phonon energy. Nanosized TaS₃ samples showed step-like conductivity as a function of strain, demonstrating the association of the steps with the quantization of the CDW wave vector.⁹⁶ In o-TaS₃, the asymmetrical conductivity had no dependency below a certain temperature (2 K), which was caused by soliton transport in the CDW system.97 Nichols et al. studied the frequency and voltage dependencies of voltage-induced torsional strain in o-TaS₃ and concluded that the strain is allied with a divergence in the CDW instead of the CDW current.98 A change in the length, L, (depending on the electric field and time) of TaS₃ samples demonstrated that hysteresis partly corresponds with resistance.⁹⁹ Thermal expansion studies of o-TaS₃ crystals showed the uncharacteristic behaviour of the hysteresis loop of length L below the Peierls transition temperature and at 100 K, the elastic modulus meets the Young's modulus of the CDW wave.100 Gorlova and co-workers observed electric-field-induced torsional strain corresponding to colossal shear in TaS₃ whiskers.¹⁰¹ The threshold and hysteresis behaviour of torsion demonstrated its link with CDW deformation. Correspondingly, Nichols et al. investigated the effects of hysteretic voltageinduced torsional strain on CDW depinning in o-TaS₃ using square-wave and triangular-wave voltages of dissimilar frequencies and amplitudes.¹⁰² Inagaki et al. reported the magnetoresistance of a CDW in o-TaS3 whiskers under a magnetic field up to 4.2 K. When the field was aligned with the a-axis, the maximum amplitude of angle-dependent magnetoresistance was achieved, whereas there was zero value at the baxis.¹⁰³ Electrical transport measurements of single o-TaS₃ by Farley et al. discovered the depression of the Peierls transition temperature to 205 K. Below this temperature, there was depinning of the CDW, which was accredited to broadening of the electric field and surface confinement; low dimensionality and a limited size effect caused a great enhancement in the threshold voltage for the nucleation of CDW dislocations (Fig. 6).¹⁰⁴ Wu et al. studied the pressure-dependent vibrational properties, which imply that the one and only S_{\parallel} mode (at 54 cm⁻¹) was held accountable for the crystalline orientation of TaS₃ through angle-resolved Raman spectroscopy and highpressure diamond anvil cell studies.105 Frequency-dependent conductivity measurements showed the Drude type behaviour of the inertial feedback of TaS₃, associated with damping.¹⁰⁶

Material	Starting precursors	Growth conditions	Heating temperature; substrate	Size	Ref. no.
TiS ₃ crystals	Ti sheets, S powder	Vacuum-sealed (10 ⁻⁶ torr) ampoule, 5 davs	520 $^{\circ}$ C; wall of quartz tube	Bulk crystals	24
TiS ₃ thin film	TiCl ₄ , <i>t</i> -butyl disulfide	Vacuum heating (10^{-1} torr)	260 °C; glass, and Ti and Al foil	Large-area thin film	127
TiS ₃ nanowhiskers	Ti metal foil, S powder	Vacuum-sealed (10 ⁻⁵ torr) ampoule, 3 days	$500^\circ\text{C};$ Ti foil and wall of quartz ampoule	$l = 100 \mu\text{m}, w = \text{few } \mu\text{m}, t = 0.5 \mu\text{m}$	28 and 124
TiS ₃ nanoribbons	Ti disc, S powder	Vacuum-sealed (10 ⁻³ torr) ampoule, 20 h	520 $^\circ\mathrm{C};$ wall of quartz tube	l = 100	144
ZrS ₃ flakes	Zr metal sheets, S pellet	Vacuum-sealed (10 ⁻⁶ torr) ampoule, 5 days	650 $^\circ\mathrm{C};$ wall of quartz tube	Bulk needles and mechanically exfoliated flakes	25 and 144
ZrSe ₃ crystals and nanobelts	Zr powder, Se powder	Vacuum-sealed (10 ⁻² torr) ampoule, 24 h	650 $^{\circ}$ C; wall of quartz tube	$l =$ tens of μ m, $w = 20-2600 \text{ nm}$	129
ZrTe ₃ crystals	Zr powder, Te powder	Vacuum-sealed ampoule	950 °C (source)/850 °C (sink) and 735 °C (source)/660 °C (sink); wall of quartz tube	l = 5 mm, w = 0.8 mm, t = 0.2 mm	15
HfS ₃ crystals and flakes	Zr metal sheets, S pellet	Vacuum-sealed (10 ⁻⁶ torr) ampoule, 5 days	650 $^\circ \mathrm{C};$ wall of quartz tube	Bulk needles and mechanically exfoliated flakes	24
HfSe ₃ crystals and flakes	Hf powder, Se powder	Vacuum-sealed (10 ⁻² torr) ampoule, 24 h	650 $^{\circ}$ C; wall of quartz tube	$l =$ tens of μ m, $w = 20-2600 \text{ nm}$	129
HfTe ₃ crystals and flakes NbS ₃ whiskers and flakes	Hf powder, Te powder Nb powder, S powder	Vacuum-sealed, CVT-iodine carrier Vacuum sealed (10 ⁻⁵ torr) ampoule, 7 days	500–540 °C; wall of quartz tube 550 °C (source)/470 °C (sink); wall of quartz tube, mechanical exfoliation	l = 0.3 mm, $w = 0.3$ mm, $t = 0.1$ mm Whisker-like crystals	51 84
NbSe ₃ crystals	Nb powder, Se powder		700 $^{\circ}$ C; wall of quartz tube	l = 7.0 mm, w = 0.05 mm, t = 0.01 mm	87
NbSe ₃ nanoribbons	Nb powder, Se powder	Reaction under vacuum, >15 days	700 $^\circ \rm C;$ wall of quartz tube	$l = >10 \mu m$ to few mm, $w = t = 20-700 \mu m$	72
TaS ₃ crystals and flakes	Ta powder, S powder	Vacuum sealed, CVT-iodine carrier, 48 h	760 $^\circ\mathrm{C}\text{;}$ wall of quartz tube	l = several cm, $w = 40-900$ nm, t = 20-50 mm	132
TaSe ₃ crystals and flakes	Ta powder, Se powder	Vacuum sealed, CVT-iodine carrier, 10 days	700–600 °C; wall of quartz tube	$l = >10 \text{ mm}, w = t = \sim 200 \text{ \mum}$	107 and 108
TaSe ₃ nanowires	TaCl ₅ , Se powder	CVD growth under vacuum,	$400~^{\circ}$ C; wall of quartz tube	l = >120 nm	78

RSC Advances

TaSe₃ is reported to be superconducting below 2.1 K with anisotropic properties under the application of a magnetic field79 and Kikkawa et al. also indicated the superconductivity of $TaSe_3$ at T = 1.9 K.⁶⁵ Thickness-dependent work function variations of TaSe₃ flakes confirmed the extended screening length (24 nm) at which the work function suddenly decreased, which specified its hydrophilic nature, and the Raman modes at 128 cm⁻¹; 141, 164, 217, and 237 cm⁻¹; 177 cm⁻¹; and 186 cm⁻¹ corresponded to Bg, B2, Ag, A1g modes, respectively.107 TaSe3 is reported to have a high current-carrying capacity and high current density, and it has emerged as a possible potential candidate to act as an interconnector in electronic devices due to capping with hexagonal boron nitride (h-BN).¹⁰⁸ Experimental observations demonstrated that quasi-1D TaSe₃ nanowires transmit lower levels of normalized noise spectral density, with potential for rationalized local interdependent applications.¹⁰⁹⁻¹¹¹ The main properties of MX₃ are summed up in Fig. 7.

3. Strategies for the growth of MX₃

Synthesis approaches used for the growth of MX₃ crystals and nanostructures such as nanowhiskers, nanoribbons, nanosheets, nanowires, etc. can be classified as top-down or bottomup approaches. In this review, we have emphasized different synthesis approaches reported for MX₃ development, as summarized in Table 3. Useful methods for MX₃ include direct chemical reactions, chemical vapour transport (CVT), chemical vapour deposition (CVD), high-pressure evolution approaches, intercalation, mechanical and chemical exfoliation, etc. Characterization techniques such as X-ray diffraction (XRD), X-ray photoelectron spectroscopy (XPS), field-emission scanning electron microscopy (FESEM), atomic force microscopy (AFM), scanning tunnelling microscopy (STM), transmission electron microscopy (TEM), Raman spectroscopy, UV spectroscopy, and optical microscopy (angle-resolved as well as pressure- and temperature-dependent methods) are the usual procedures

used to estimate the properties of MX_3 materials and further help in exploring their abundant applications.¹¹²⁻¹²⁰

3.1. Bottom-up approaches

3.1.1. IV-X-type MX₃. Transition-metal trichalcogenides nanostructures, such as nanowhiskers, nanoribbons, and nanosheets, are reported to be grown based on direct reactions involving titanium and sulphur.^{2,121-126} In a typical reaction process for the growth of TiS₃ crystals and nanostructures, Ti and S are sealed in an evacuated quartz ampoule and heated up to 500-600 °C for several days (3-5 days).¹²⁴ In this approach, the sulfurization temperature and gradient used usually are \sim 500 °C and 50–100 °C, respectively. This method is also termed as a chemical vapour transport (CVT) technique, which is an excellent growth mechanism for fabricating lowdimensional materials, where sulphur, TiS_x species, and sometimes iodine are considered as transport agents.² Fig. 8¹²⁴ shows photographs of ampoules with Ti foil and S powder used for the direct reaction-based method to grow bare and doped TiS3 nanowhiskers. Fig. 8c and d124 show SEM images of nanowhiskers grown on Ti foil and the walls of the quartz tube.¹²⁴ It is reported that the critical temperature for the CVT growth of TiS₃ should be below a typical temperature, *i.e.*, 632 °C, which is the decomposition temperature of TiS_3 to TiS_2 (Table 3). TiS₃ nanoribbons and nanosheets have been fabricated via mixing Ti powder with sulphur gas through a solid-gas reaction. The sulphur powder was heated in a vacuum sealed ampoule at 550 °C (nanoribbons) and 400 °C (nanosheets) for around 15 days.²⁷ TiS₃ thin films are prepared via thermal chemical vapour deposition through reacting TiCl₄ and *t*-butyl disulphide (TBDS) at 260 °C.127 The temperature and pressure of the chamber, sulfurizing source, and flow rates of Ar and TiCl₄ play crucial roles in achieving the formation of pure TiS₃ films. Similar to the CVT growth approach for TiS₃, ZrS₃ and HfS₃ can also be grown via taking Zr and Hf elemental sheets and sulphur powder and heating them in vacuum sealed quartz ampoules at 650 °C for 5 days.^{24,128} ZrS₃ bulk powder is reported to form upon heating zirconium and sulphur powder in an



Fig. 8 The synthesis of MX₃. Optical photographs of the ampoule (a) before and (b) after the growth of TiS₃ whiskers on Ti foil and the surface of quartz. (c and d) SEM images of the grown TiS₃ whiskers with arrow marks indicating samples collected from the respective positions. Reproduced with permission from ref. 124, copyright: 2015, Royal Society of Chemistry. (e) The synthesis of $ZrTe_3$ via a chemical vapour deposition approach. (f) FESEM and TEM images of $ZrTe_3$. Republished with permission from ref. 130, permission conveyed through Copyright Clearance Center, Inc.

evacuated quartz ampoule for 150 h, and a stable colloidal dispersion could be formed in different organic media, such as iso-propanol, acetonitrile, ethanol, and dimethyl formamide, *via* a liquid exfoliation process.³⁵ ZrSe₃ and HfSe₃ nanobelts could be grown *via* a CVT approach, in which Zr or Hf powder was mingled with Se powder at a stoichiometric ratio (1 : 3).¹²⁹ The powder mixture was vacuum sealed $(10^{-2}$ Pa) in a quartz tube and heated at 650 °C for 24 h to achieve the growth of ZrSe₃ and HfSe₃ nanobelts. ZrTe₃ nanoribbons could be grown *via* a CVD approach, in which Te and ZrCl₄ powder are used as vapour sources (Fig. 8e and f).¹³⁰ Through controlling the carrier gas flow (Ar: 30 sccm and H₂: 35 sccm), heating temperature (650–750 °C), and growth time (20–80 min), high-quality and single-crystal nanoribbons could be grown on a SiO₂/Si substrate placed downstream of the quartz tube.¹³⁰

3.1.2. V–X-type MX₃. The growth of NbX₃- and TaX₃-based transition metal trichalcogenides has been reported using similar CVT approaches as followed for the IV–X MX₃ group, and some of the results are summarized in Table 3. Whisker-like NbSe₃ nanowires were prepared *via* the direct reaction of a Nb and Se powder mixture placed in a small alumina crucible, sealed under vacuum and heated for 24 h.⁸⁹ Hor *et al.* reported an effective single-step approach for the synthesis of NbSe₃

nanowires and nanoribbons.⁷² In this approach, stoichiometric quantities of Nb and Se were sealed and heated in a quartz ampoule at 630-700 °C to achieve the growth of pure and crystalline nanoribbons.⁸⁹ Pham et al. reported a facile method to prepare few-to-single chain structures of NbSe₃, encapsulated in BN or CNT sheaths to prevent oxidation.¹³¹ In this approach, Nb and Se powder was mixed with cap-opened CNTs/BNNTs and vacuum sealed at 10^{-1} torr in a quartz ampoule, followed by heating at 690 °C for 5-9 days. Wu et al. reported the preparation of TaS₃ nanobelts at 760 °C for 48 h in a quartz ampoule *via* a CVT approach, with iodine as the transport agent.¹³² Single crystals of o-TaS₃ are reported to be formed *via* a CVT approach upon heating Ta sheets and S powder in a sealed quartz tube at 530 °C for a few weeks.¹⁰³ Long nanofibers of o-TaS₃ can be prepared via heating Ta and S precursors in a sealed quartz ampoule at 500 °C for 48 h.134 Farley et al. prepared o-TaS3 nanoribbons via heating Ta foil and S powder at 550 °C for 2 h in a vacuum-sealed tube.¹⁰⁴ The sublimed sulphur travelled across the tube due to a temperature gradient inside the tube and reacted with TaS₃, o-TaS₃ whiskers were prepared via a CVT approach in a quartz ampoule through maintaining two heating zones at 650 °C and 550 °C in a tube furnace for 7 days.105 In a similar approach, Li et al. reported the generation of large-



Fig. 9 (a) The crystallographic structure of TaSe₃. (b) A schematic diagram of the CVD set-up for the growth of TaSe₃ nanowires. (c) An optical image and (d and e) SEM images of a population of TaSe₃ nanowires. Reprinted with permission from ref. 78, copyright: 2019, American Chemical Society. (f) A schematic illustration of the mechanical exfoliation of TaSe₃ flakes from bulk TaSe₃. (g) A 3D representation of a quasi-1D TaSe₃ nanovibon monolayer on a SiO₂/Si substrate. Reproduced with permission from ref. 107, copyright: 2019, Multidisciplinary Digital Publishing Institute. (h) Source-drain current vs. voltage for a 11.6 nm TaSe₃ nanowire in a 2-electrode configuration, with the inset showing an SEM image of the device. (i) Resistivity as a function of bundle width of CVD-grown TaSe₃ nanowires and a comparison with bulk Cu and exfoliated TaSe₃. (j) The current density response of a 7 × 7 nm² nanowire as a function of V_{ds} with failure at a current density of 108 A cm⁻². Reprinted with permission from ref. 78, copyright: 2019, American Chemical Society.



Fig. 10 A schematic diagram showing the various applications of MX₃. Solar and fuel cell figure republished with permission from ref. 33, permission conveyed through Copyright Clearance Center, Inc.; lithium-ion batteries figure reprinted with permission from ref. 134, copyright: 2015, American Chemical Society; sensors figure reprinted with permission from ref. 133, copyright: 2018, American Chemical Society; photodetectors figure republished with permission from ref. 129, permission conveyed through Copyright Clearance Center, Inc.; FETs figure reproduced with permission from ref. 124, copyright: 2015, Royal Society of Chemistry; thermoelectricity figure republished with permission from ref. 157, permission conveyed through Copyright Clearance Center, Inc.; central figure reproduced with permission from ref. 6, copyright: 2015, Springer Nature.

scale and self-supported TaS₃ nanowires *via* the direct reaction of Ta and S powder in a sealed quartz tube at 650 °C for 1 h.¹³⁴ To prepare TaSe₃ crystals, Ta and Se precursors are heated under

vacuum at a pressure of 1 GPa at 500-700 °C for 30-240 min.135 Stolyarov et al. followed a two-step CVT approach; in the first step, a Ta, Se, and iodine mixture was heated in a quartz ampoule at 900 °C for 12 h, and in the second step, the product was heated in a tube furnace with a temperature gradient of 700-680 °C.^{108,110} In the CVD approach, TaCl₅ and Se powder samples were used as the reactants and heated at 400 °C for 15 min with Ar and H₂ as ambient process gases to grow TaSe₃ nanowires on SiO₂/Si placed upstream near an alumina crucible filled with TaCl₅ (Fig. 9a-e).⁷⁸ In another work, Kim et al. prepared single-crystal TaSe₃ via a CVT approach, mixing stoichiometric amounts of Ta, Se, and iodine powder and heating this at 670 °C for 10 days, maintaining the growth zone at 600 °C, and later mechanically exfoliating it from bulk $TaSe_3$ (Fig. 9f-g).¹⁰⁷ Empante et al. reported low resistivity and a high collapse current density of 10⁸ A cm⁻² for a single nanowire, which featured an electro-migration energy barrier twice that of Cu (Fig. 9h-j).78

3.2. Top-down approaches

Chemical and mechanical exfoliation methods are widespread synthesis tactics that have gained huge interest in the field of top-down approaches.^{137,138} Mostly, as-prepared bulk crystals are taken as a prime precursor and subsequent chemical intercalation or power-driven force approaches are applied to these. Then, through force or intercalation, the neighbouring layers get detached from adjacent layers. Weak van der Waals forces co-existing between neighbouring layers plays a vibrant role in the materialization of few- to mono-layer crystals of 2D materials upon controlling the relevant parameters. Similarly, the ultrasonication of bulk powder or crystals in solvents is widely



Fig. 11 Few-layered TiS_3 FETs. (a) A schematic diagram and (b) an SEM image of a typical FET. (c) Conductivity vs. gate voltage dependencies of four different fabricated FETs, with the inset showing drain source current vs. drain source voltage at different gate voltages. Reproduced with permission from ref. 124, copyright: 2015, Royal Society of Chemistry.



Fig. 12 The hydrogen photogeneration properties of MX_3 nanostructures. (a) An SEM image and (b) the conduction and valence band energy levels on potential (V vs. NHE) and energy (eV vs. vacuum) scales, with the redox potentials for the water-splitting half reactions at pH = 9.0 vs. NHE, of TiS₃ nanoribbons. The hydrogen evolution flow of TiS₃ nanoribbons (c) at 0.0 V and (d) at different bias potentials. Republished with permission from ref. 144, permission conveyed through Copyright Clearance Center, Inc.

used for liquid exfoliation to achieve single- to few-layered nanosheets.

the other hand, liquid phase exfoliation is an effective method for the large-scale production of MX_3 nanosheets.¹³⁹ Few-layer TiS₃ material was prepared by Island *et al.* at a temperature of 400 °C with sheet-like morphology, and this was later

Mechanical exfoliation is a widely used method to isolate single- to few-layered MX₃ nanosheets from bulk material.⁶ On



Fig. 13 The application of MX_3 heterostructures to solar cells. (a) Band offsets of ZrS_3/HfS_3 and TcS_2/ReS_2 with the vacuum level as zero reference. (b) PCE contours obtained as a function of the donor band gap and conduction band offset. (c) A schematic illustration of thin-film solar cells with the associated mechanism. Republished with permission from ref. 33, permission conveyed through Copyright Clearance Center, Inc.

mechanically exfoliated to few-layer form.⁶ Xie *et al.* reported the liquid phase exfoliation of bulk ZrS₃ in *n*-propylamine for 30 min followed by heating at 120 °C for 3 days in a Teflon-lined autoclave.¹³⁹ The obtained product was washed and ultrasonicated in 1-cyclohexyl-2-pyrrolidinone to achieve ZrS₃ nanosheets. NbS₃ and NbSe₃ nanoparticle colloidal solutions were prepared *via* a top-down approach through the ultrasonication of powder in different solutions (DMF, acetone, acetonitrile, ethanol, a water–ethanol mixture, *etc.*) for 3 h. Liion intercalation is proposed as a suitable method to prepare MX₃ nanoribbons, in which three lithium atoms are incorporated into an MX₃ unit to yield Li₃MX₃.¹⁴⁰ A mechanical exfoliation approach is employed to prepare few-layered flakes from TaSe₃ crystals (Fig. 9f and g).¹⁰⁷ A schematic diagram of the different steps used in this process is shown in Fig. 9, in which wafer dicing tape is used and stuck onto the crystal, which is then removed and adhered to the SiO_2/Si substrate.

4. Advanced applications of MX₃

4.1. FETs

The possible applications of TMTCs are shown in Fig. 10. Due to the direct optical band gap (\sim 1 eV) and ultra-high response of TiS₃, it has been used as an appropriate material for field-effect transistors with high gain.^{125,126} FETs based on 2D sheets of TiS₃ whiskers (mechanically exfoliated few-layered samples) have been fabricated on SiO₂/Si substrates (Fig. 11a and b).¹²⁴ n-Type electronic transport TiS₃-based FETs exhibited mobilities of 18– 24 cm² V⁻¹ s⁻¹, and this was improved to 43 cm² V⁻¹ s⁻¹ upon the addition of another substrate, *i.e.*, Al₂O₃, through



Fig. 14 (a) A schematic illustration of a $ZrSe_3$ and $HfSe_3$ single nanobelt photodetector. SEM images of (b) $ZrSe_3$ and (c) the $HfSe_3$ photodetector. *I–V* characteristics of (d) $ZrSe_3$ and (e) the $HfSe_3$ nanobelt photodetector. Republished with permission from ref. 129, permission conveyed through Copyright Clearance Center, Inc.

a conventional atomic layer deposition (ALD) procedure. Similarly, the ON/OFF ratio improved to 7000 from 300 upon the use of Al₂O₃ as an alternative substrate (Fig. 11c).¹²⁴ The temperaturedependent transfer curves of TiS3 nanowire FETs showed a metal-insulator transition, with a cross-over temperature of 220 K and mobility of 20-30 cm² V⁻¹ s⁻¹.¹⁴¹ To demonstrate the anisotropic electrical properties, a TiS3 nanosheet FET device was made up, with electrodes at 30° intervals.¹²⁶ The fabricated FET device worked along the *b*-axis of the TiS₃ nanosheets, which was determined via computing the transfer characteristics across the device between two opposite electrodes at variable angles. A polar plot of current vs. voltage showed the high mobility of $80 \text{ cm}^2 \text{ V}^{-1}$ s^{-1} (*b*-axis) and low mobility of 40 cm² V⁻¹ s⁻¹ (*a*-axis) of the nanosheets. Transfer characteristics curves showed n-type behaviour, with an ON/OFF ratio of five.¹²⁶ The nanoribbons showed lower mobilities with advanced electric field and optical properties, which later can be tuneable. The multifaceted concentration of sulphur vacancies in samples grown at lower temperature played an important role in creating tuneable properties upon an intensification in the n-type dopant.¹²⁶ The interfacial and contact properties of multi-layered TiS₃ and metals (Au, Ag, Pd, Pt, Ir, and Ni) have been inspected *via* DFT and the outcomes suggested the absence of tunnelling barriers, demonstrating superior carrier injection abilities from the metal to multilayer TiS₃ in FET and other electrical devices.¹⁴² The output characteristics of FETs based on HfS₃ nanobelts confirmed the p-type semiconducting nature.¹⁴² Therefore, from the above data, it is quite evident that these materials are first and foremost highly suitable materials for nanoelectronics and optoelectronic devices.

4.2. Solar and fuel cell devices

Solar water splitting using photoelectrochemical cells is an effective and efficient way of storing solar energy in the form of hydrogen, which can be used as a fuel. For hydrogen generation *via* water splitting, the light absorbing material with appropriate energy band positions, *i.e.*, the energy band levels (CB and VB), should be suitable with respect to the water reduction potential.^{143,163} Anisotropic MX₃ materials possess the advantages of having a low band gap to absorb direct solar energy and



Fig. 15 (a) The crystal structure of NbS₃. (b) Optical microscopy and (c) SEM images of a NbS₃ crystal. Schematic diagrams of (d) a NbS₃ photodetector and (e) bending conditions. (f) ON–OFF photovoltage curves at room temperature and (g) resistance, response time, and photovoltage data under different bending conditions. Reprinted with permission from ref. 151, copyright: 2020, American Chemical Society.

being widely available, non-toxic, and suitable for photoelectrochemical water splitting. Fig. 12a¹⁴⁴ shows an SEM image of TiS₃ nanoribbons, which have been employed as an active material for electrochemical water splitting.¹⁴⁴ The systematic energy level band diagram of TiS₃/electrolyte (Na₂SO₃) is shown in Fig. 12b¹⁴⁴ with a flat band potential ($V_{\rm fb}$) at $-0.48 V_{\rm NHE}$, and this is used to calculate the semiconductor Fermi level. The conduction and valence band energy levels in terms of potential and energy balance, along with the redox potentials for the water splitting half reactions at pH = 9, are shown in the band diagram. Hydrogen evolution occurs on the TiS₃ nanoribbons at 0 V and investigations at different bias potentials yielded a photoconversion efficiency of about 7% at a bias potential of 0.3 V (Fig. 12c and d).144 In another work, Flores et al. demonstrated the energy level schemes for an MX₃/electrolyte interface, and comparable photogenerated hydrogen fluxes are reported for TiS₃, ZrS₃, and HfS₃.¹⁴⁵ A TiS₃ photoanode is reported to generate up to 19 nmol H_2 per min per cm² at an external bias potential of 0.3 V vs. Ag/AgCl. Due to the presence of copious amounts of Se₂ bonds on the surface of the ZrS₃ ultrathin nanosheets, enhanced oxygen evolution reaction performance was observed compared to the bulk counterpart.139 A low onset overpotential of 244 mV and Tafel slope of 45 mV per decade are achieved using ZrS₃ nanosheets in strongly alkaline solution (pH = 14), whereas in weakly alkaline solution (pH = 6.9), the onset over-potential and Tafel slope are reported to be lower.139

The use of 2D materials and their heterojunctions in optoelectronics and solar-correlated devices is utterly controlled by the superiority of the heterojunction formed and the band alignment to tune carriers at interfaces.³³ Zhao *et al.* employed DFT to calculate the band superstructures and heterostructures

of IV-VIA monolayers of MX_3 (M = Zr, Hf; X= S, Se) and VIIB-VIA monolayer MX_2 (M = Tc, Re; X = S, Se). The calculations indicated that for MX₃, the valence bands are dependent on the p-states of chalcogens, whereas the d-states of the transition metals control the conduction bands. For MX₂ monolayers, both the valence and conduction bands depend on the d-states of the transition metals. Considering standard water redox potentials (-4.44 eV and -5.67 eV for reduction (H^+/H_2) and oxidation (O_2/H_2O) , respectively), the combination of MX₃ and MX₂ monolayers and their band alignment to create efficient heterostructures have been reported.³³ Fig. 13³³ shows the bandoffset components and a contour map of power conversion efficiency (PCE) values. From calculations, it is predicted that a ZrS₃/HfS₃ bilayer thin-film device could achieve 16-18% efficiency, which is much higher than other reported 2D heterojunction solar cell devices. Similarly, Ahammed et al. reported that the PCEs in ZrS₃/MoS₂, ZrS₃/WS₂, ZrS₃/MoSeTe, ZrS₃/WSTe, and ZrS_3 /WSeTe heterostructured bilayers are as high as ~12%, 8%, 16%, 14%, and 14%, respectively.¹⁴⁶ Recently, anisotropic ZrS₃ has been reported to act as an active material for perovskite light-emitting diodes and P-N junction diodes, and the results are found to be promising, which opens up pathways for further research into the area of MX₃ heterojunctions for optoelectronics and solar-cell devices.147,148

4.3. Photodetectors and sensors

Island *et al.* reported the photoresponse properties of TiS₃nanoribbon-based FETs.¹²⁵ TiS₃ FETs showed a high photoresponse of up to 2910 A W⁻¹, and fast switching times of \sim 4 ms, with a cut-off frequency of 100 Hz, showing promise for photodetection and photovoltaic applications. Tao *et al.* reported flexible a visible light photodetector formed on ZrS₃



Fig. 16 (a) Schematic representations of a FET, NO gas sensor, and photodetector based on TaS_3 nanofibers. (b) An SEM image of the TaS_3 nanofibers. (c) The impedance phase responses of gas sensors fabricated on different substrates (polyester, parafilm, paper) as functions of NO concentrations. (d) Selectivity studies of the sensors fabricated on different substrates. (e) An optical image of a FET based on TaS_3 fibers. (f) FET transistor characteristic curves at different gate voltages (pink: -1 V, blue: 0 V, green: 1 V, red: 2 V, black: 3 V). (g) Dark current (black) and responsivity (red) curves. Reprinted with permission from ref. 133, copyright: 2018, American Chemical Society.

nanobelt film, which showed high spectral selectivity, a wide range, and a rapid photoresponse in the visible light to nearinfrared region.¹⁴⁹ Photodetectors based on HfS₃ FETs showed a huge ON/OFF ratio of 337.5, along with an ultralow dark current of 0.04 pA at 405 nm under 1.2 mW cm⁻² light excitation.^{32,142} CVT-deposited ZrSe₃ and HfSe₃ were investigated for photodetection applications.¹²⁹ Under excitation by 650 nm wavelength light, a ZrSe₃ photodetector showed a light ON/OFF ratio of 1.92 at 50 s with a bias voltage of 5 V (Fig. 14).129 Similarly, a HfSe₃ nanobelt photodetector showed an ON/OFF ratio of 2.2 with an average time of 50 s, and the photoresponse time was 0.4 s. Although HfTe₃-based materials are reported to show interesting properties, including CDWs, superconductivity, and the ability to be used in quantum Hall-effect-related devices, they have been less studied to date.^{51,150} Wu et al. reported a photothermoelectric (PTE) detector based on NbS3 with considerable performance in the UV to terahertz range.¹⁵⁰ Considering its immense surface-to-volume ratio and reduced magnitude, mechanically exfoliated quasi-1D NbS₃ crystals prepared via a CVT approach were studied for photodetector

applications (Fig. 15a-d).¹⁵¹ Various types of continuous-wave lasers were used to test the photoresponse performance, including UV (375 nm), near-infrared (NIR, 1064 and 1550 nm), visible (635 nm), and semiconductor lasers, a mid-infrared (MIR, 10.6 μ m) CO₂ laser, and a terahertz-wave-generating farinfrared gas laser (118.8 µm) (Fig. 15e).¹⁵¹ The photodetector based on NbS₃ flakes showed good performance, with responsivities higher than 1 V W⁻¹, a response time of \sim 7 ms, and robust flexibility and stability (Fig. 15e-g).¹⁵¹ Via employing the interesting structural and attractive electronic properties of layered TaS₃ prepared in the form of nanofibers, Pumera and co-workers reported a highly selective impedimetric NO gas sensor, FET and photodetector (Fig. 16).¹³³ The nanofibers showed metallic character, with a metal-semiconducting transition below 210 K, prompted by CDW formation. The impedimetric gas sensor showed an excellent response towards NO when fabricated on different substrates (Fig. 16).¹³³ A TaS₃based sensor fabricated on a polyester substrate showed the best sensing performance, with a limit of detection (LOD) of 0.48 ppb.



Fig. 17 SEM images of (a) NbSe₃ and (b) NbSe₃@rGO. (c) A TEM image of NbSe₃@rGO. The electrochemical performance of NbSe₃ and NbSe₃@rGO in the voltage range of 0.005-3 V vs. Li/Li⁺. Discharge and charge curves of (d) NbSe₃ and (e) nanobelts. (f) The cycling performance of NbSe₃@rGO and NbSe₃ nanobelts at a current density of 100 mA g⁻¹. (g) The rate performances of NbSe₃@rGO and NbSe₃ nanobelts. Reprinted from ref. 155, copyright: 2017, with permission from Elsevier.



Fig. 18 (a) An SEM image of TaS₃ nanowires. (b) Voltage profiles of a lithium-ion battery based on TaS₃ nanowires cycled between 0.001 and 3 V vs. Li⁺/Li at a cycling rate of 0.1C. (c) Capacity and coulombic efficiency as a function of cycle number for a TaS₃ nanowire electrode at a cycling rate of 0.1C. (d) An SEM image of nanowires after long-term cycling tests. (e) Rate performance and coulombic efficiency as a function of cycle number for TaS₃ electrodes and as a function of discharge rate (0.1-10C). (f–h) A schematic diagram of a fabricated flexible lithium-ion battery with photographs showing a glowing LED powered by flat and bent states. Reprinted with permission from ref. 134, copyright: 2015, American Chemical Society.

4.4. Lithium ion batteries

Due to their multi-electron processes with high theoretical capacity, MX₃-based materials have emerged as potential active materials for lithium- and sodium-ion battery applications.152-155 Wu et al. investigated Li/Na adsorption and diffusion in bulk, few-layer, and monolayer TiS₃ via studying the phase stability, electron properties, adsorption and dispersion properties, capacity, and plateaus. Charge density and Bader charge analysis studies provided information about the interactions of Li/Na with nearby atoms.152 The above-mentioned analysis methods also confirmed significant charge transfer from Li or Na atoms to surrounding sulphur atoms, and this effect was prominent in monolayer TiS₃. Amorphous TiS₃, prepared via the ball milling of TiS₂ and S, is testified to show a capacity of 400 mA h g⁻¹ when used as a Li-ion battery electrode material.¹⁵³ Tanibata et al. reported an all-solid-state sodium cell using TiS₃ as the active material, which showed a capacity of over 300 mA h g^{-1} during the first chargedischarge process.¹⁵⁴ The capacity of a cell with a TiS₃ electrode is reported to be three times higher than that of a cell with TiS₂ crystals. Ex situ characterization (XRD and Raman spectroscopy) studies of the electrode materials after long-term cycling tests confirmed that TiS₃ maintained its amorphous nature and local structure. Considering the advantages of its metallic nature and the high surface area of NbSe₃, Li et al. demonstrated its application as an anode material in lithium-ion batteries.155 Pure and NbSe₃ nanobelts wrapped with reduced graphene oxide (rGO) were prepared via a chemical approach (Fig. 17ac).¹⁵⁵ The wrapped rGO utilized strain from NbSe₃ structural distortion to suppress impairment induced by volume alterations in the structure of NbSe₃ nanobelts during chargedischarge cycles (Fig. 17g).¹⁵⁵ NbSe₃@rGO showed a discharge capacity of 300 mA h g⁻¹ after 250 cycles at a current density of 100 mA g⁻¹, which was four times greater than that of untainted NbSe₃ nanobelts. Li *et al.* demonstrated self-supported and flexible lithium ion battery anode electrodes based on TaS₃ nanowires with a good reversible capacity of ~400 mA h g⁻¹ after 100 cycles at 0.1C with 0.1% decay (Fig. 18).¹³⁴ Due to the continuous and interconnected nature of the TaS₃ nanowires, binder-free and self-supported electrodes could be fabricated, which not only enabled fast electron and ion access but also provided high mechanical flexibility in the fabricated cells.

4.5. Thermoelectricity

The thermoelectric effect is mainly a translation between temperature gradients in a material and electronic voltage, and it also works contrariwise. Thermoelectric constituents convert heat into electric power and they have been used to design ecofriendly and sustainable energy sources.^{136,157} The efficiency of thermoelectric materials is estimated based on the figure of merit parameter, $ZT = S^2 \sigma T/k$, where S, σ , T, and k are the Seebeck co-efficient, electrical conductivity, absolute temperature, and thermal conductivity, respectively. The thermal conductivity component includes both electronic (k_e) and phonon (lattice, k_l) parts. Hence, a proper combination of S, σ , and k is expected to lead to high-performance thermoelectric materials. Some strategies, such as using low-dimensional structures, alloy defects, band engineering, *etc.*, have been employed for this purpose.¹⁵⁸⁻¹⁶¹ The thermoelectric properties of MX₃ materials are reported to show robust anisotropic behaviour in bulk, few-layer, and monolayer form.¹⁶² Wang et al. reported that the power factor $(S^2\sigma)$ along the Y-direction is increased compared to that along the X-direction for ZrS₃.¹⁶² Phonon transport findings also demonstrate large anisotropy characteristics induced by unlike scattering from layered ZrS₃ along the X and Z directions and different group velocities along the X and Y directions. DFT studies of ZrSe₃ monolayers reveal that corrugated conduction levels can result in solid anisotropy of the electric transport characteristics.³⁰ It has also been reported that heat transference in ZrSe₃ monolayers is completely under-controlled by superficial Se atoms. The large bond lengths of the Zr-Se1 and Zr-Se2 chains confine their influence on heat transference and unswervingly lead to low levels of lattice thermal conductivity.

5. Summary and future directions

Thorough experimental and theoretical studies of quasi-1D MX_3 have shown their wide range of applications in the fields of condensed matter physics and nanotechnology due to their various outstanding electrical, optical, magnetic, and CDW properties, and strong in-plane anisotropy with a quasi-1D nature. The dynamic crystal structures and new fabrication techniques of these materials are well depicted in this work. Also, novel applications based on these materials can be expanded to countless conceivable concepts, which can be viewed perfectly based on the above details.

Weak van der Waals forces of attraction between layers and anisotropy along the chain axis (*b*-axis) provide MX₃ materials with the advantages of both structural (2D layered material and quasi-1D) and electrical (CDW phenomena) properties. In MX₃, the chalcogen atoms (S, Se, Te) are considered to be electron reservoirs, thus providing exceptional electronic properties, arising from bulk and nanostructured materials. The M atom presents at the centres of all prismatic chains of MX₆, which are linked to each other in an infinite chain manner and run parallel to the *b*-axis. At the base of the prism of MX₃, one bond is shorter compared to the others, so more research needs to be carried out in this direction utilizing the advantages of this property, so that new applications of these materials can be explored. Even TiS₃ shows strong dichroism in agreement with systematic anisotropy. Similarly, the creation of different types of vacancies in the TiS₃ system leads to the induction of a definite magnetic moment. Spin-orbit interactions in the case of ZrX₃ materials result in an increase in the energy split from S to Se atoms. Certain phonon modes undergo a dramatic linewidth reduction near $T_{\rm CDW}$, representing the strong coupling of phonons with electronic degrees of freedom associated with the CDW for ZrTe₃. However, huge attention and focus should be given to the interesting property of MX₃, *i.e.*, the CDW, so that the shift in the CDW transition can be well-understood and numerous unexplored applications can be instigated in this direction. High-end techniques and better qualitative practical methods, like solid-state NMR, photon correlation spectroscopy, X-ray diffraction topography (XRT), in situ and ex situ

characterization (XRD, SEM, and TEM), muon-spectroscopy, terahertz spectroscopy, *etc.*, can be engaged to study and visualize the LRO pyramid in few-layer or monolayer MX_3 . The properties are quite poor along the *a*-axis, and they can be tuned *via* the application of external pressure, strain, *etc.* More and more focus should be given to studying the anisotropy in the *a*-axis direction, which is somewhat present in some metal tritellurides and will be helpful for outstanding applications in the field of nanotechnology. Therefore, these properties open up the endless possibility for spectacular applications. In contrast, 2D layered material characteristics are somehow not properly shown by the materials due to the quasi-1D nature.

Synthesis approaches for MX₃ materials are quite costeffective and environmentally friendly and less timeconsuming in comparison to other 2D material families, like MXenes. These methods include direct chemical reactions, chemical vapour transport (CVT), chemical vapour deposition (CVD), mechanical and chemical exfoliation, etc. Subsequently, other atoms can be intercalated into the layers of MX₃ in line with the feeble van der Waals forces. Characterization techniques such as X-ray diffraction (XRD), X-ray photoelectron spectroscopy (XPS), field-emission scanning electron microscopy (FESEM), electron-dispersive X-ray analysis (EDAX), atomic force microscopy (AFM), scanning tunnelling microscopy (STM), transmission electron microscopy (TEM), Raman spectroscopy, UV-visible spectroscopy, and optical microscopy are typical methods used to appraise the properties of MX₃ materials. Mostly, CVD and CVT methods are used for producing bulk as well as nanostructured materials with layers of few mm to nm thickness. As monolayer materials show interesting and research-driven properties, innovative and scalable exfoliation techniques can be used to form thin monolayers.

Most materials are fabricated *via* taking both precursors at a particular stoichiometry, placing them into a vacuum-sealed ampule, and heating them at a certain temperature for a precise amount of time. Later, after the system cools down, the prepared samples are removed. *Via* these methods, nanowhiskers, nanoribbons, nanosheets, *etc.* of MX₃ (TiS₃, ZrX₃, HfX₃, NbX₃) are prepared, and their characterization is carried out *via* the above-stated techniques. However, these methods are exceedingly time consuming, and some experiments take 15 days. Therefore, more effective strategies should be implemented for the growth of bulk as well as monolayered MX₃. Upgraded CVD and CVT systems with high-end programming for the skillful flow of inert gases (Ar, H₂, N₂, or a mixture of any two) and proper temperature maintaining tools should be prearranged to control the number of layers and their thickness.

 MX_3 materials show a wide range of applications, *e.g.*, FETs, solar and fuel cells, lithium-ion batteries, photodetectors, photosensors, and thermoelectrics. The higher mobilities and greater ON/OFF ratios of MX_3 -based FETs are worth noting in the present day. MX_3 materials possess the advantages of having a low band gap to absorb direct solar energy, and being low-cost, plentiful, and appropriate for photoelectrochemical water splitting, making them suitable candidates for use in solar and fuel cells. The maximum efficiency reached is about 16–20%. The high photoresponse, fast switching time, and high

Review

cut-off frequency make MX₃ the best material for use in sensors and photodetectors. MX₃ can also be used in converting heat into electrical power due to its transport properties. Despite all the merits possessed by MX₃, these materials are well behind in terms of real-world applications, like in supercapacitors, sodium-ion batteries, etc. These materials can be fused with carbon-based materials (single-walled and multiwalled carbon nanotubes and rGO) for supercapacitor applications due to their high surface areas. The efficiencies of solar cells can be improved via the incorporation and doping of active elements, which can allow more focus on the real-world applications of MX₃. Work should be done to increase the capacities of lithiumion batteries based on MX₃ via the strong intercalation of other atoms into the layers of MX₃. The photoresponse can be enhanced along with the switching time in photodetectors. MX₃ materials can be used for building biosensors, as they are nontoxic and eco-friendly in nature.

This review article highlights the significance of the in-plane anisotropy and quasi-1D nature of MX_3 materials, with a complete study of the atomic structures, physical and chemical properties, intrinsic modulations in CDW states, cost- and time-effective synthesis methodologies, and related plausible applications. We contemplate optimistically that this fragment of work on quasi-1D MX_3 materials, the evolution of their primary properties, and their related applications will have contemporary significance, leading to novel and fresh research.

Conflicts of interest

There are no conflicts to declare.

Acknowledgements

This work was financially supported by the Department of Science and Technology (DST)-SERB Early Career Research project (Grant No. ECR/2017/001850), DST (DST/NM/NT/2019/205(G); DST/TDT/SHRI-34/2018), and Karnataka Science and Technology Promotion Society (KSTePS/VGST-RGS-F/2018-19/GRD No. 829/315).

References

- 1 J. Xu, J. Zhang, W. Zhang and C.-S. Lee, *Adv. Energy Mater.*, 2017, 7, 1700571.
- 2 J. O. Island, A. J. Molina-Mendoza, M. Barawi, R. Biele,
 E. Flores, J. M. Clamagirand, J. R. Ares, C. Sánchez,
 H. S. J. van der Zant, R. D'Agosta, I. J. Ferrer and
 A. Castellanos-Gomez, *2D Materials*, 2017, 4, 022003.
- 3 J. Dai, M. Li and X. C. Zeng, Wiley Interdiscip. Rev.: Comput. Mol. Sci., 2016, 6, 211–222.
- 4 S. K. Srivastava and B. N. Avasthi, J. Mater. Sci., 1992, 27, 3693–3705.
- 5 J. Gopalakrishnan and K. S. Nanjundaswamy, *Bull. Mater. Sci.*, 1983, **5**, 287–306.
- 6 J. O. Island, R. Biele, M. Barawi, J. M. Clamagirand, J. R. Ares, C. Sánchez, H. S. J. van der Zant, I. J. Ferrer,

R. D'Agosta and A. Castellanos-Gomez, *Sci. Rep.*, 2016, 6, 1–7.

- 7 F. Iyikanat, R. T. Senger, F. M. Peeters and H. Sahin, *ChemPhysChem*, 2016, 17, 3985-3991.
- 8 R. Sun, Y. Gu, G. Yang, J. Wang, X. Fang, N. Lu, B. Hua and X. Yan, *J. Phys. Chem. C*, 2019, **123**, 7390–7396.
- 9 J. Kang and L.-W. Wang, *Phys. Chem. Chem. Phys.*, 2016, **18**, 14805–14809.
- 10 J. Dai and X. C. Zeng, Angew. Chem., 2015, 127, 7682-7686.
- 11 Y. Aierken, D. Çakır and F. M. Peeters, *Phys. Chem. Chem. Phys.*, 2016, **18**, 14434–14441.
- 12 W. Schairer and M. W. Shafer, *Phys. Status Solidi A*, 1973, **1**7, 181–184.
- 13 E. Canadell, Y. Mathey and M. H. Whangbo, *J. Am. Chem. Soc.*, 1988, **110**, 104–108.
- 14 C. Felser, E. W. Finckh, H. Kleinke, F. Rocker and W. Tremel, *J. Mater. Chem.*, 1998, **8**, 1787–1798.
- 15 X. Zhu, B. Lv, F. Wei, Y. Xue, B. Lorentz, L. Deng, Y. Sun and C.-W. Chu, *Phys. Rev. B*, 2013, **87**, 024508.
- 16 A. J. Molina-Mendoza, M. Barawi, R. Biele, E. Flores, J. R. Ares, C. Sánchez, G. Bollinger, N. Agraït, R. D'Agosta, I. J. Ferrer and A. Castellanos-Gomez, *Adv. Electron. Mater.*, 2015, 1, 1500126.
- R. Biele, E. Flores, J. R. Ares, C. Sanchez, I. J. Ferrer, G. Rubio-Bollinger, A. Castellanos-Gomez and R. D'Agosta, *Nano Res.*, 2017, 11, 225–232.
- 18 A. Khatibi, R. H. Godiksen, S. B. Basuvalingam,
 D. Pellegrino, A. A. Bol, B. Shokri and A. G. Curto, 2D Materials, 2019, 7, 015022.
- 19 F. Iyikanat, H. Sahin, R. T. Senger and F. M. Peeters, *J. Phys. Chem. C*, 2015, **119**, 10709–10715.
- 20 J. Kang, H. Sahin, H. D. Ozaydin, R. T. Senger and F. M. Peeters, *Phys. Rev. B: Condens. Matter Mater. Phys.*, 2015, **92**, 075413.
- 21 D. Pacilé, M. Papagno, M. Lavagnini, H. Berger, L. Degiorgi and M. Grioni, *Phys. Rev. B: Condens. Matter Mater. Phys.*, 2007, 76, 155406.
- 22 A. Ait-Ouali and S. Jandl, *Phys. Rev. B: Condens. Matter Mater. Phys.*, 1996, **53**, 9852–9858.
- 23 A. Pant, E. Torun, B. Chen, S. Bhat, X. Fan, K. Wu,
 D. P. Wright, F. M. Peeters, E. Soignard, H. Sahin and
 S. Tongay, *Nanoscale*, 2016, 8, 16259–16265.
- 24 W. Kong, C. Bacaksiz, B. Chen, K. Wu, M. Blei, X. Fan, Y. Shen, H. Sahin, D. Wright, D. S. Narang and S. Tongay, *Nanoscale*, 2017, 9, 4175–4182.
- 25 X. Wang, K. Wu, M. Blei, Y. Wang, L. Pan, K. Zhao, C. Shan, M. Lei, Y. Cui, B. Chen, D. Wright, W. Hu, S. Tongay and Z. Wei, *Adv. Electron. Mater.*, 2019, 5, 1900419.
- 26 H. Jin, D. Cheng, J. Li, X. Cao, B. Li, X. Wang, X. Liu and X. Zhao, *Solid State Sci.*, 2011, **13**, 1166–1171.
- 27 A. S. Pawbake, J. O. Island, E. Flores, J. R. Ares, C. Sanchez,
 I. J. Ferrer, S. R. Jadkar, H. S. J. van der Zant, A. Castellanos-Gomez and D. J. Late, *ACS Appl. Mater. Interfaces*, 2015, 7, 24185–24190.
- 28 K. Wu, E. Torun, H. Sahin, B. Chen, X. Fan, A. Pant, D. Parsons Wright, T. Aoki, F. M. Peeters, E. Soignard and S. Tongay, *Nat. Commun.*, 2016, 7, 1–7.

- 29 K. Patel, J. Prajapati, R. Vaidya and S. G. Patel, *Bull. Mater. Sci.*, 2005, **28**, 405–410.
- 30 Z. Zhou, H. Liu, D. Fan, G. Cao and C. Sheng, ACS Appl. Mater. Interfaces, 2018, 10, 37031–37037.
- 31 M. Li, J. Dai and X. Cheng Zeng, *Nanoscale*, 2015, 7, 15385– 15391.
- 32 Y.-R. Tao, J.-Q. Chen, J.-J. Wu, Y. Wu and X.-C. Wu, *J. Alloys Compd.*, 2016, **658**, 6–11.
- 33 Q. Zhao, Y. Guo, Y. Zhou, Z. Yao, Z. Ren, J. Bai and X. Xu, *Nanoscale*, 2018, **10**, 3547–3555.
- 34 A. Zwick, M. A. Renucci and A. Kjekshus, J. Phys. C: Solid State Phys., 1980, 13, 5603–5614.
- 35 P. Poltarak, A. Poltarak, S. Artemkina, T. Podlipskaya, I. Asanov and V. Fedorov, *Colloids Surf.*, A, 2019, 579, 123667.
- 36 S. L. Gleason, Y. Gim, T. Byrum, A. Kogar, P. Abbamonte, E. Fradkin, G. J. MacDougall, D. J. Van Harlingen, X. Zhu, C. Petrovic and S. L. Cooper, *Phys. Rev. B: Condens. Matter Mater. Phys.*, 2015, 15, 155124.
- 37 I. G. Gorlova, S. G. Zybtsev, V. Y. Pokrovskii, N. B. Bolotina,
 I. A. Verin and A. N. Titov, *Phys. B*, 2012, 407, 1707–1710.
- 38 T. Ritschel, J. Trinckauf, K. Koepernik, B. Büchner, M. v. Zimmermann, H. Berger, Y. I. Joe, P. Abbamonte and J. Geck, *Nat. Phys.*, 2015, 11, 328–331.
- 39 H. Feng, Z. Xu, J. Zhuang, L. Wang, Y. Liu, X. Xu, L. Song,
 W. Hao and Y. Du, *Adv. Funct. Mater.*, 2019, 29, 1900367.
- 40 S. Takahashi, T. Sambongi, J. W. Brill and W. Roark, *Solid State Commun.*, 1984, **49**, 1031–1034.
- 41 H. Nakajima, K. Nomura and T. Sambongi, *Physica B+C*, 2002, **143**, 240–242.
- 42 M. Hoesch, X. Cui, K. Shimada, C. Battaglia, S. Fujimori and H. Berger, *Phys. Rev. B: Condens. Matter Mater. Phys.*, 2009, **80**, 075423.
- 43 D. J. Eaglesham, J. W. Steeds and J. A. Wilson, *J. Phys. C:* Solid State Phys., 1984, 17, L697–L698.
- 44 Y. Hu, F. Zheng, X. Ren, J. Feng and Y. Li, *Phys. Rev. B: Condens. Matter Mater. Phys.*, 2015, **91**, 144502.
- 45 K. Yamaya, S. Takayanagi and S. Tanda, *Phys. Rev. B:* Condens. Matter Mater. Phys., 2012, **85**, 184513.
- 46 M. Hoesch, A. Bosak, D. Chernyshov, H. Berger and M. Krisch, *Phys. Rev. Lett.*, 2009, **102**, 086402.
- 47 R. Yomo, K. Yamaya, M. Abliz, M. Hedo and Y. Uwatoko, *Phys. Rev. B: Condens. Matter Mater. Phys.*, 2005, **71**, 132508.
- 48 M. Hoesch, G. Garbarino, C. Battaglia, P. Aebi and H. Berger, *Phys. Rev. B*, 2016, **93**, 125102.
- 49 X. Zhu, W. Ning, L. Li, L. Ling, R. Zhang, J. Zhang, K. Wang, Y. Liu, L. Pi, Y. Ma, H. Du, M. Tian, Y. Sun, C. Petrovic and Y. Zhang, *Sci. Rep.*, 2016, 6, 26974.
- 50 C. S. Yadav and P. L. Paulose, *J. Phys.: Condens. Matter*, 2012, 24, 235702.
- 51 J. Li, J. Peng, S. Zhang and G. Chen, *Phys. Rev. B*, 2017, **96**, 174510.
- 52 T. Ikari, R. Provencher, S. Jandl and M. Aubin, *Solid State Commun.*, 1983, **45**, 113–116.
- 53 S. Lai and Y. Du, Materials, 2019, 12, 3501.

- 54 V. Y. Pokrovskii, S. G. Zybtsev, M. V. Nikitin, I. G. Gorlova,
 V. F. Nasretdinova and S. V. Zaitsev-Zotov, *Phys.-Usp.*, 2013, 56, 29–48.
- 55 M. A. Bloodgood, P. Wei, E. Aytan, K. N. Bozhilov, A. A. Balandin and T. T. Salguero, *APL Mater.*, 2018, **6**, 026602.
- 56 F. Jellinek, G. Brauer and H. Müller, *Nature*, 1960, **185**, 376–377.
- 57 J. Rijnsdorp and F. Jellinek, *J. Solid State Chem.*, 1978, 25, 325–328.
- 58 D. W. Bullett, J. Solid State Chem., 1980, 33, 13-16.
- 59 M. E. Itkis, F. Y. Nad', S. V. Zaitsev-Zotov and F. Lévy, *Solid State Commun.*, 1989, **71**, 895–898.
- 60 M. E. Itkis, F. Y. Nad' and F. Levy, Synth. Met., 1991, 43, 3969-3972.
- 61 Z. Z. Wang, P. Monceau, H. Salva, C. Roucau, L. Guemas and A. Meerschaut, *Phys. Rev. B: Condens. Matter Mater. Phys.*, 1989, **40**, 11589–11593.
- 62 J. W. Brill, H. Zhang and J. Nichols, *Phys. B*, 2012, **407**, 1737–1740.
- 63 T. Cornelissens, G. Van Tendeloo, J. Van Landuyt and S. Amelinckx, *Phys. Status Solidi A*, 1978, **48**, K5–K9.
- 64 E. Zupanič, H. J. P. van Midden, M. A. van Midden, S. Šturm, E. Tchernychova, V. Y. Pokrovskii, S. G. Zybtsev, V. F. Nasretdinova, S. V. Zaitsev-Zotov, W. T. Chen, W. W. Pai, J. C. Bennett and A. Prodan, *Phys. Rev. B*, 2018, 98, 174113.
- 65 S. Kikkawa, N. Ogawa, M. Koizumi and Y. Onuki, *J. Solid State Chem.*, 1982, **41**, 315–322.
- 66 S. G. Zybtsev, V. Y. Pokrovskii, V. F. Nasretdinova, S. V. Zaitsev-Zotov, V. V. Pavlovskiy, A. B. Odobesco, W. W. Pai, M.-W. Chu, Y. G. Lin, E. Zupanič, H. J. P. van Midden, S. Šturm, E. Tchernychova, A. Prodan, J. C. Bennett, I. R. Mukhamedshin, O. V. Chernysheva, A. P. Menushenkov, V. B. Loginov, B. A. Loginov, A. N. Titov and M. Abdel-Hafiez, *Phys. Rev. B*, 2017, 95, 035110.
- 67 A. Zettl, C. M. Jackson, A. Janossy, G. Grüner, A. Jacobsen and A. H. Thompson, *Solid State Commun.*, 1982, 43, 345– 347.
- 68 A. Meerschaut and J. Rouxel, *J. Less-Common Met.*, 1975, **39**, 197–203.
- 69 P. Monçeau, N. P. Ong, A. M. Portis, A. Meerschaut and J. Rouxel, *Phys. Rev. Lett.*, 1976, **37**, 602–606.
- 70 J. L. Hodeau, M. Marezio, C. Roucau, R. Ayroles,
 A. Meerschaut, J. Rouxel and P. Monceau, *J. Phys. C: Solid State Phys.*, 1978, 11, 4117–4134.
- 71 R. M. Fleming, D. E. Moncton and D. B. McWhan, *Phys. Rev. B: Solid State*, 1978, **18**, 5560–5563.
- 72 Y. S. Hor, Z. L. Xiao, U. Welp, Y. Ito, J. F. Mitchell,
 R. E. Cook, W. K. Kwok and G. W. Crabtree, *Nano Lett.*, 2005, 5, 397–401.
- 73 R. E. Thorne, W. G. Lyons, J. W. Lyding, J. R. Tucker and J. Bardeen, *Phys. Rev. B: Condens. Matter Mater. Phys.*, 1987, 35, 6348–6359.
- 74 C. Brun, Z.-Z. Wang and P. Monceau, *Phys. Rev. B: Condens. Matter Mater. Phys.*, 2009, **80**, 045423.

- 75 A. Meerschaut, L. Guemas and J. Rouxel, *J. Solid State Chem.*, 1981, **36**, 118–123.
- 76 F. Jellinek, J. Less-Common Met., 1962, 4, 9-15.
- 77 E. Bjerkelund and A. Kjekshus, Z. Anorg. Allg. Chem., 1964, 328, 235–242.
- 78 T. A. Empante, A. Martinez, M. Wurch, Y. Zhu,
 A. K. Geremew, K. Yamaguchi, M. Isarraraz,
 S. Rumyantsev, E. J. Reed, A. A. Balandin and L. Bartels, *Nano Lett.*, 2019, 19, 4355–4361.
- 79 T. Sambongi, M. Yamamoto, K. Tsutsumi, Y. Shiozaki,
 K. Yamaya and Y. Abe, *J. Phys. Soc. Jpn.*, 1977, 42, 1421– 1422.
- 80 E. Bjerkelund, A. Kjekshus, G. Widmark, P. H. Nielsen,
 B. Sjöberg and E. Larsen, *Acta Chem. Scand.*, 1965, 19, 701–710.
- 81 E. M. Dizhur, M. A. Il'ina and S. V. Zaĭtsev-Zotov, *JETP Lett.*, 2007, **86**, 132–134.
- 82 V. E. Fedorov, S. B. Artemkina, E. D. Grayfer, N. G. Naumov,
 Y. V. Mironov, A. I. Bulavchenko, V. I. Zaikovskii,
 I. V. Antonova, A. I. Komonov and M. V. Medvedev, *J. Mater. Chem. C*, 2014, 2, 5479–5486.
- 83 S. B. Artemkina, E. D. Grayfer, M. N. Kozlova, S. G. Kozlova, M. R. Ryzhikov, I. R. Shein and V. E. Fedorov, *Spectrochim. Acta, Part A*, 2017, **179**, 46–50.
- 84 K. Wu, M. Blei, B. Chen, L. Liu, H. Cai, C. Brayfield,
 D. Wright, H. Zhuang and S. Tongay, *Adv. Mater.*, 2020, 32, 2000018.
- 85 H. M. McConnell and R. Lynden-Bell, J. Chem. Phys., 1962, 36, 2393–2397.
- 86 C. Sourisseau, R. Cavagnat, M. Fouassier and P. Maraval, J. Raman Spectrosc., 1990, 21, 337–349.
- 87 J. Chaussy, P. Haen, J. C. Lasjaunias, P. Monceau, G. Waysand, A. Waintal, A. Meerschaut, P. Molinié and J. Rouxel, *Solid State Commun.*, 1976, 20, 759–763.
- 88 S. van Smaalen, J. L. de Boer, A. Meetsma, H. Graafsma, H.-S. Sheu, A. Darovskikh, P. Coppens and F. Levy, *Phys. Rev. B: Condens. Matter Mater. Phys.*, 1992, 45, 3103–3106.
- 89 H. Shi, H. Yang, H. Tian, Z. Wang, Y. Qin, Y. Song, M. Luo, W. Wang and J. Li, *J. Nanosci. Nanotechnol.*, 2013, 13, 4123– 4128.
- 90 M. Ido, Y. Okayama, T. Ijiri and Y. Okajima, *J. Phys. Soc. Jpn.*, 1990, **59**, 1341–1347.
- 91 Y. I. Latyshev, O. Laborde, P. Monceau and S. Klaumünzer, *Phys. Rev. Lett.*, 1997, **78**, 919–922.
- 92 L. Yang, Y. Tao, J. Liu, C. Liu, Q. Zhang, M. Akter, Y. Zhao, T. T. Xu, Y. Xu, Z. Mao, Y. Chen and D. Li, *Nano Lett.*, 2018, 19, 415–421.
- 93 N. P. Ong and P. Monceau, *Solid State Commun.*, 1978, **26**, 487–491.
- 94 C. Roucau, R. Ayroles, P. Monceau, L. Guemas, A. Meerschaut and J. Rouxel, *Phys. Status Solidi A*, 1980, 62, 483–493.
- 95 S. Sugai, *Phys. Rev. B: Condens. Matter Mater. Phys.*, 1984, **29**, 953–965.
- 96 S. G. Zybtsev and V. Y. Pokrovskii, *Phys. Rev. B*, 2016, **94**, 115140.

- 97 K. Inagaki, T. Toshima and S. Tanda, *J. Phys. Chem. Solids*, 2005, **66**, 1563–1566.
- 98 J. Nichols, D. Dominko, L. Ladino, J. Zhou and J. W. Brill, *Phys. Rev. B: Condens. Matter Mater. Phys.*, 2009, **79**, 241110.
- 99 S. Hoen, B. Burk, A. Zettl and M. Inui, *Phys. Rev. B: Condens. Matter Mater. Phys.*, 1992, 46, 1874–1877.
- 100 A. V. Golovnya, V. Y. Pokrovskii and P. M. Shadrin, *Phys. Rev. Lett.*, 2002, **88**, 246401.
- 101 V. Pokrovskii, S. Zybtsev and I. Gorlova, *Phys. Rev. Lett.*, 2007, **98**, 206404.
- 102 J. Nichols, C. Sandamali Weerasooriya and J. W. Brill, J. Phys.: Condens. Matter, 2010, 22, 334224.
- 103 K. Inagaki, T. Matsuura, M. Tsubota, S. Uji, T. Honma and S. Tanda, *Phys. Rev. B*, 2016, **93**, 075423.
- 104 K. E. Farley, Z. Shi, G. Sambandamurthy and S. Banerjee, *Phys. Chem. Chem. Phys.*, 2015, **17**, 18374–18379.
- 105 K. Wu, B. Chen, H. Cai, M. Blei, J. Bennett, S. Yang, D. Wright, Y. Shen and S. Tongay, *J. Phys. Chem. C*, 2017, 121, 28187–28193.
- 106 S. Sridhar, D. Reagor and G. Gruner, *Phys. Rev. Lett.*, 1985, 55, 1196–1199.
- 107 B. J. Kim, B. J. Jeong, S. Oh, S. Chae, K. H. Choi, T. Nasir, S. H. Lee, H. K. Lim, I. J. Choi, M.-K. Hong, H. K. Yu, J.-H. Lee and J.-Y. Choi, *Materials*, 2019, **12**, 2462.
- 108 M. A. Stolyarov, G. Liu, M. A. Bloodgood, E. Aytan, C. Jiang, R. Samnakay, T. T. Salguero, D. L. Nika, S. L. Rumyantsev, M. S. Shur, K. N. Bozhilov and A. A. Balandin, *Nanoscale*, 2016, 8, 15774–15782.
- 109 G. Kumagai, T. Matsuura, K. Ichimura, K. Yamaya, K. Inagaki and S. Tanda, *Phys. Rev. B: Condens. Matter Mater. Phys.*, 2010, 81, 184506.
- 110 G. Liu, S. Rumyantsev, M. A. Bloodgood, T. T. Salguero, M. Shur and A. A. Balandin, *Nano Lett.*, 2016, 17, 377–383.
- 111 A. Nomura, K. Yamaya, S. Takayanagi, K. Ichimura, T. Matsuura and S. Tanda, *Europhys. Lett.*, 2017, **119**, 17005.
- 112 Y.-H. Chang, W. Zhang, Y. Zhu, Y. Han, J. Pu, J.-K. Chang, W.-T. Hsu, J.-K. Huang, C.-L. Hsu, M.-H. Chiu, T. Takenobu, H. Li, C.-I. Wu, W.-H. Chang, A. T. S. Wee and L.-J. Li, *ACS Nano*, 2014, **8**, 8582–8590.
- 113 J. Zhou, J. Lin, X. Huang, Y. Zhou, Y. Chen, J. Xia, H. Wang, Y. Xie, H. Yu, J. Lei, D. Wu, F. Liu, Q. Fu, Q. Zeng, C.-H. Hsu, C. Yang, L. Lu, T. Yu, Z. Shen, H. Lin, B. I. Yakobson, Q. Liu, K. Suenaga, G. Liu and Z. Liu, *Nature*, 2018, **556**, 355–359.
- 114 H. Li, Y. Li, A. Aljarb, Y. Shi and L.-J. Li, *Chem. Rev.*, 2017, 118, 6134–6150.
- 115 Z. Zhang, P. Yang, M. Hong, S. Jiang, G. Zhao, J. Shi, Q. Xie and Y. Zhang, *Nanotechnology*, 2019, **30**, 182002.
- 116 S. Tongay, W. Fan, J. Kang, J. Park, U. Koldemir, J. Suh, D. S. Narang, K. Liu, J. Ji, J. Li, R. Sinclair and J. Wu, *Nano Lett.*, 2014, 14, 3185–3190.
- 117 S. Wang, X. Wang and J. H. Warner, ACS Nano, 2015, 9, 5246-5254.
- 118 K. M. McCreary, A. T. Hanbicki, J. T. Robinson, E. Cobas, J. C. Culbertson, A. L. Friedman, G. G. Jernigan and B. T. Jonker, *Adv. Funct. Mater.*, 2014, 24, 6449–6454.
- 119 Z. Chen, Y. Qi, X. Chen, Y. Zhang and Z. Liu, *Adv. Mater.*, 2018, **31**, 1803639.

- 120 P. Chen, Z. Zhang, X. Duan and X. Duan, *Chem. Soc. Rev.*, 2018, **47**, 3129–3151.
- 121 H. Haraldsen, A. Kjekshus, E. Røst, A. Steffensen and J. Munch-Petersen, *Acta Chem. Scand.*, 1963, **17**, 1283–1292.
- 122 L. Brattås, A. Kjekshus, J. Krogh-Moe, J. Songstad and Å. Pilotti, *Acta Chem. Scand.*, 1972, **26**, 3441–3449.
- 123 S. Kikkawa, M. Koizumi, S. Yamanaka, Y. Onuki and S. Tanuma, *Phys. Status Solidi A*, 1980, **61**, K55–K57.
- 124 A. Lipatov, P. M. Wilson, M. Shekhirev, J. D. Teeter, R. Netusil and A. Sinitskii, *Nanoscale*, 2015, 7, 12291–12296.
- 125 J. O. Island, M. Buscema, M. Barawi, J. M. Clamagirand, J. R. Ares, C. Sánchez, I. J. Ferrer, G. A. Steele, H. S. J. van der Zant and A. Castellanos-Gomez, *Adv. Opt. Mater.*, 2014, 2, 641–645.
- 126 J. O. Island, M. Barawi, R. Biele, A. Almazán, J. M. Clamagirand, J. R. Ares, C. Sánchez, H. S. J. van der Zant, J. V. Álvarez, R. D'Agosta, I. J. Ferrer and A. Castellanos-Gomez, *Adv. Mater.*, 2015, 27, 2595–2601.
- 127 H. S. W. Chang and D. M. Schleich, *J. Solid State Chem.*, 1992, **100**, 62–70.
- 128 H. Yi, S. J. Gilbert, A. Lipatov, A. Sinitskii, J. Avila, J. Abourahma, T. Komesu, M. C. Asensio and P. A. Dowben, *J. Phys.: Condens. Matter*, 2020, 32, 29LT01.
- 129 W.-W. Xiong, J.-Q. Chen, X.-C. Wu and J.-J. Zhu, *J. Mater. Chem. C*, 2015, **3**, 1929–1934.
- 130 X. Yu, X. Wen, W. Zhang, L. Yang, H. Wu, X. Lou, Z. Xie, Y. Liu and H. Chang, *CrystEngComm*, 2019, **21**, 5586–5594.
- 131 T. Pham, S. Oh, P. Stetz, S. Onishi, C. Kisielowski, M. L. Cohen and A. Zettl, *Science*, 2018, **361**, 263–266.
- 132 X. Wu, Y. Tao, Y. Hu, Y. Song, Z. Hu, J. Zhu and L. Dong, *Nanotechnology*, 2005, **17**, 201–205.
- 133 C. C. Mayorga-Martinez, Z. Sofer, J. Luxa, Š. Huber, D. Sedmidubský, P. Brázda, L. Palatinus, M. Mikulics, P. Lazar, R. Medlín and M. Pumera, ACS Nano, 2017, 12, 464–473.
- 134 W. Li, L. Yang, J. Wang, B. Xiang and Y. Yu, *ACS Appl. Mater. Interfaces*, 2015, 7, 5629–5633.
- 135 S. Kikkawa, K. Shinya and M. Koizumi, *J. Solid State Chem.*, 1982, **41**, 323–328.
- 136 E. Canadell, I. E. I. Rachidi, J. P. Pouget, P. Gressier, A. Meerschaut, J. Rouxel, D. Jung, M. Evain and M. H. Whangbo, *Inorg. Chem.*, 1990, **29**, 1401–1407.
- 137 T. Lu, S. Dong, C. Zhang, L. Zhang and G. Cui, *Coord. Chem. Rev.*, 2017, **332**, 75–99.
- 138 Z. Lei, J. Zhan, L. Tang, Y. Zhang and Y. Wang, *Adv. Energy Mater.*, 2018, **8**, 1703482.
- 139 J. Xie, R. Wang, J. Bao, X. Zhang, H. Zhang, S. Li and Y. Xie, *Inorg. Chem. Front.*, 2014, **1**, 751–756.
- 140 R. R. Chianelli and M. B. Dines, *Inorg. Chem.*, 1975, 14, 2417–2421.
- 141 M. Randle, A. Lipatov, A. Kumar, C.-P. Kwan, J. Nathawat,B. Barut, S. Yin, K. He, N. Arabchigavkani, R. Dixit,T. Komesu, J. Avila, M. C. Asensio, P. A. Dowben,

A. Sinitskii, U. Singisetti and J. P. Bird, ACS Nano, 2018, 13, 803-811.

- 142 W.-W. Xiong, J.-Q. Chen, X.-C. Wu and J.-J. Zhu, *J. Mater. Chem. C*, 2014, 2, 7392–7395.
- 143 X. Chen, S. Shen, L. Guo and S. S. Mao, *Chem. Rev.*, 2010, 110, 6503–6570.
- 144 M. Barawi, E. Flores, I. J. Ferrer, J. R. Ares and C. Sánchez, *J. Mater. Chem. A*, 2015, **3**, 7959–7965.
- 145 E. Flores, J. R. Ares, I. J. Ferrer and C. Sánchez, *Phys. Status Solidi RRL*, 2016, **10**, 802–806.
- 146 R. Ahammed, A. Rawat, N. Jena, Dimple, M. K. Mohanta and A. De Sarkar, *Appl. Surf. Sci.*, 2020, **499**, 143894.
- 147 P. He, X.-X. Wang, Y.-Z. Cai, J.-C. Shu, Q.-L. Zhao, J. Yuan and M.-S. Cao, *Nanoscale*, 2019, **11**, 6080–6088.
- 148 R. Späh, M. Lux-Steiner, E. Bucher and S. Wagner, *Appl. Phys. Lett.*, 1984, **45**, 744–745.
- 149 Y.-R. Tao, X.-C. Wu and W.-W. Xiong, *Small*, 2014, **10**, 4905–4911.
- 150 Y.-Q. Wang, X. Wu, Y.-L. Wang, Y. Shao, T. Lei, J.-O. Wang, S.-Y. Zhu, H. Guo, L.-X. Zhao, G.-F. Chen, S. Nie, H.-M. Weng, K. Ibrahim, X. Dai, Z. Fang and H.-J. Gao, *Adv. Mater.*, 2016, 28, 5013–5017.
- 151 W. Wu, Y. Wang, Y. Niu, P. Wang, M. Chen, J. Sun, N. Wang,
 D. Wu and Z. Zhao, ACS Appl. Mater. Interfaces, 2020, 12, 14165–14173.
- 152 J. Wu, D. Wang, H. Liu, W.-M. Lau and L.-M. Liu, *RSC Adv.*, 2015, 5, 21455–21463.
- 153 A. Hayashi, T. Matsuyama, A. Sakuda and M. Tatsumisago, *Chem. Lett.*, 2012, **41**, 886–888.
- 154 N. Tanibata, T. Matsuyama, A. Hayashi and M. Tatsumisago, *J. Power Sources*, 2015, 275, 284–287.
- 155 J. Li, Q. Sun, Z. Wang, J. Xiang, B. Zhao, Y. Qu and B. Xiang, *Appl. Surf. Sci.*, 2017, **412**, 113–120.
- 156 K. Biswas, J. He, I. D. Blum, C.-I. Wu, T. P. Hogan, D. N. Seidman, V. P. Dravid and M. G. Kanatzidis, *Nature*, 2012, **489**, 414–418.
- 157 A. Banik, S. Roychowdhury and K. Biswas, *Chem. Commun.*, 2018, **54**, 6573–6590.
- 158 J. Sun, H. Shi, T. Siegrist and D. J. Singh, *Appl. Phys. Lett.*, 2015, **107**, 153902.
- 159 J. Shen, X. Zhang, S. Lin, J. Li, Z. Chen, W. Li and Y. Pei, *J. Mater. Chem. A*, 2016, 4, 15464–15470.
- 160 Y. Pei, X. Shi, A. LaLonde, H. Wang, L. Chen and G. J. Snyder, *Nature*, 2011, **473**, 66–69.
- 161 S. Lin, W. Li, X. Zhang, J. Li, Z. Chen and Y. Pei, *Inorg. Chem. Front.*, 2017, **4**, 1066–1072.
- 162 C. Wang, C. Zheng and G. Gao, *J. Phys. Chem. C*, 2020, **124**, 6536–6543.
- 163 D. Zhao, S. Budhi, A. Rodriguez and R. T. Koodali, *Int. J. Hydrogen Energy*, 2010, **35**, 5276–5283.
- 164 D. W. Bullett, J. Phys. C: Solid State Phys., 1979, 12, 277-281.
- 165 M. Abdulsalam and D. P. Joubert, *Phys. Status Solidi B*, 2016, 253, 868–874.
- 166 F. Lévy and H. Berger, J. Cryst. Growth, 1983, 61, 61-68.